Femtosecond Laser Micromachining: Applications in Photonics and Biology

Jonathan Ashcom Raffael Gattass Iva Maxwell Limin Tong Eli Glezer **Chris Schaffer** Nan Shen Debjyoti Datta **Philip LeDuc Donald E. Ingber**

Modern Optics and Spectroscopy Seminar, MIT Cambridge, MA, 11 March 2003



Introduction

Abstract-A review is given of recent experimental results on laserinduced electric breakdown in transparent optical solid materials. A fundamental breakdown threshold exists characteristic for each material. The threshold is determined by the same physical process as de breakdown, namely, avalanche ionization. The dependence of the threshold on laser pulse duration and frequency is consistent with this process. The implication of this breakdown mechanism for laser bulk and surface damage to optical of this orcanoown mechanism for user outs and surface namines to optical components is discussed. It also determines physical properties of self-

THE history of laser-induced electric breakdown focused filaments. is almost as old as the history of lasers itself. Early in

1963 Maker et al. [1] reported damage to transparent dielectrics and the production of a spark in air by focusing sulsed ruby laser beam. The importance of these the production of laser-induced dense montolinpart

Laser-Induced Electric Breakdown in Solids NICOLAAS BLOEMBERGEN, FELLOW, IEEE plasmas and for the propagation characteristics of highpower laser beams through solids, liquids, and gases was quickly recognized. The subject of electric breakdown in transparent optical solids, including laser materials, windows, and other optical components, remained, until recently, largely an empirical or engineering science. Although a vast amount of theoretical and experimental effort was expended in the economically and technically important problem of optical damage, quantitative reproducible breakdown thresholds with unambiguous theoretical interpretations have been obtained only during the last two years. The situation was somewhat analogous to the development of our understanding of the problem of de breakdown in electrical insulators. There, too, the field developed largely by engineering trial and error. Basic quantitative understanding was not achieved until reproducible experimental results on well-defined materials were obtained [2]. The difficulties in de because associments were manifold: the influence of

Introduction

On the state of the second state of the second

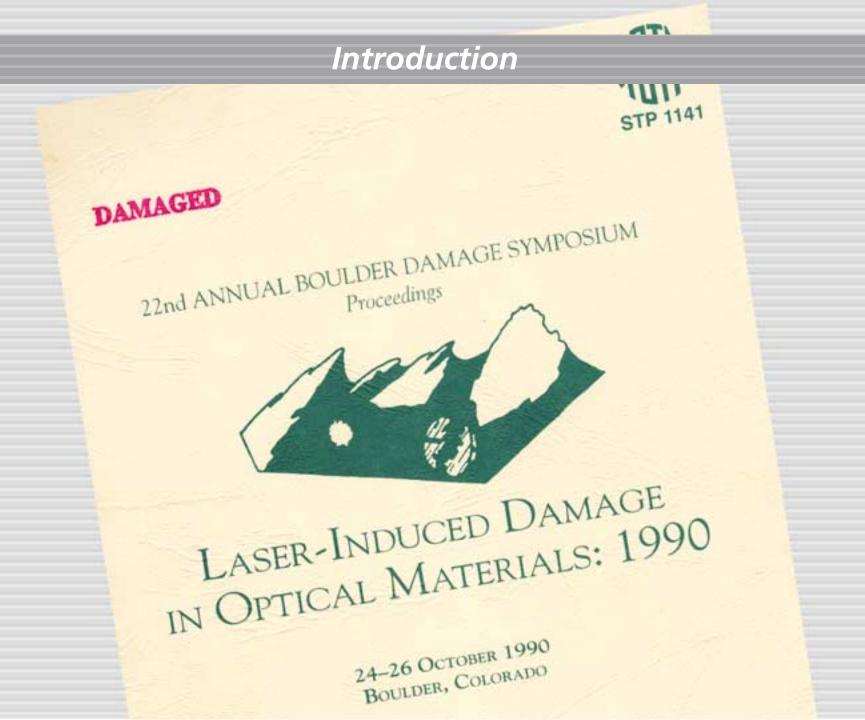
Laser-Induced Electric Breakdown in Solids

SICOLANS BLOTMBLEDES, DATION, DAT

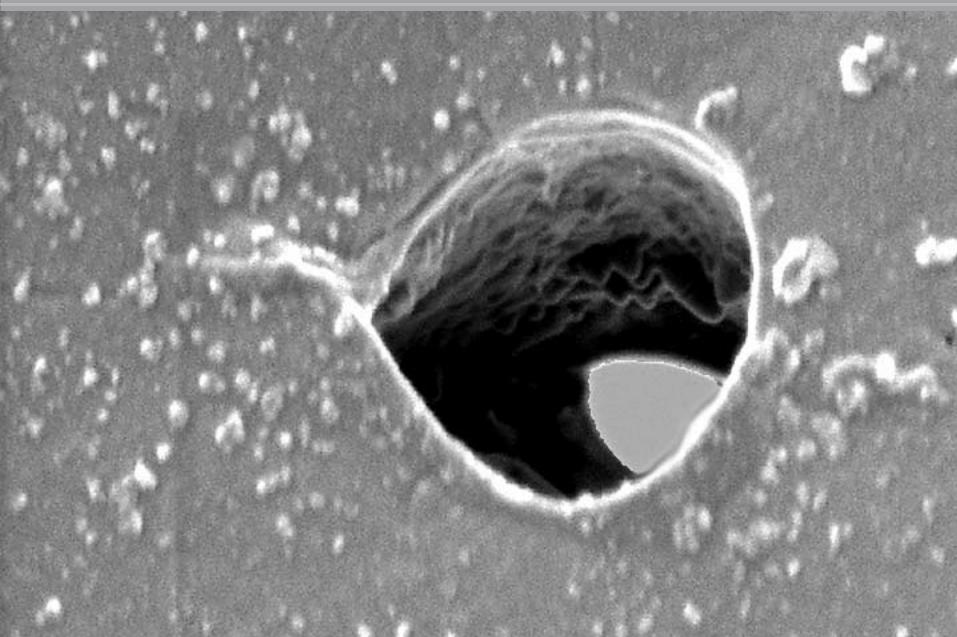
induced whereas breakdown in transporter is optic at solar materials. A sum damental breakdown for short abure store account or you'll material. On directed to determine the the same threaded process as its breakdown, introduce to sector many row stress presses where at the Drusheim on Sava manyAs, at double heavy atom. Vie dependence of the Drusheim on Sava public the advection of the sources in a constraint with the desired of the original advect of this breakdown much much for their book and surface damage to optical emponythe in discussion of the destruction of the second properties of whi-

T^{int} therein a treatment along the treatment of the tre Long-solid Addressed Sta (out stoket etche all treamed damage versionsparent fielderings with the prediction of a smark man by theory subsit subsitive them. The importance of these

plusters and for the propagation characteristics of high binet from brannerbraugh solube Equilibrium proses was querely reconcilied. The subject of electric breakdown of transmission operation and a methodatic based analyticals, action down and other oppical components remained, and seconds, hereby in surplus if or entimetron some Millionable Constraints of theorem and experimental effort was experied in the contempoter and rectionate ministrant provident of optical damage automation terreductive breakdown thresholds with unantitude the steps of uncertainty have been obtained unly during the rest two weaks. The scheduling ways and which decided to dot development at our understanding of the problem or de breakdown of the tracit mediators. The fortune the tield developed forcely by enconcernational error Wester with an of the standard of the standard with epicolositile experimental peoples on well-defined manstrale were detained (2). the defluctures in ste the infinence of analytic the infinence of



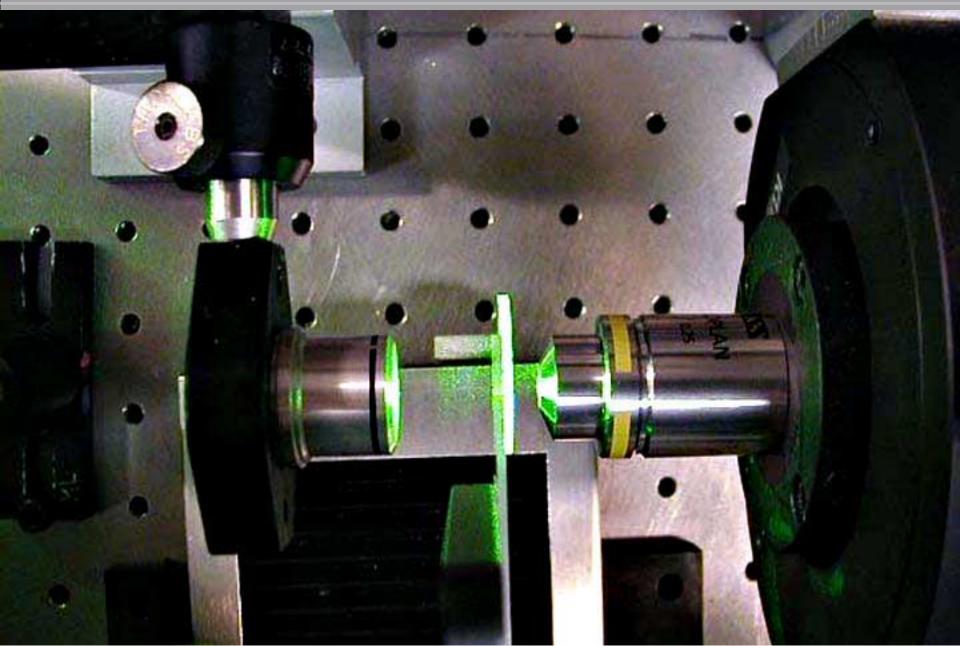
Introduction



use damage for processing!

Introduction

Outline

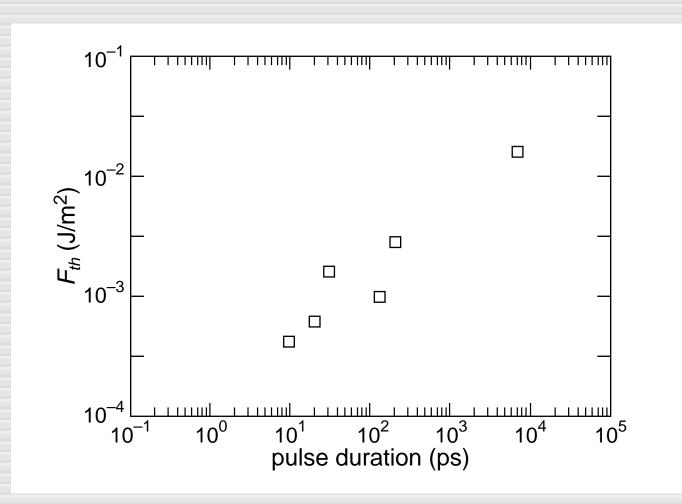


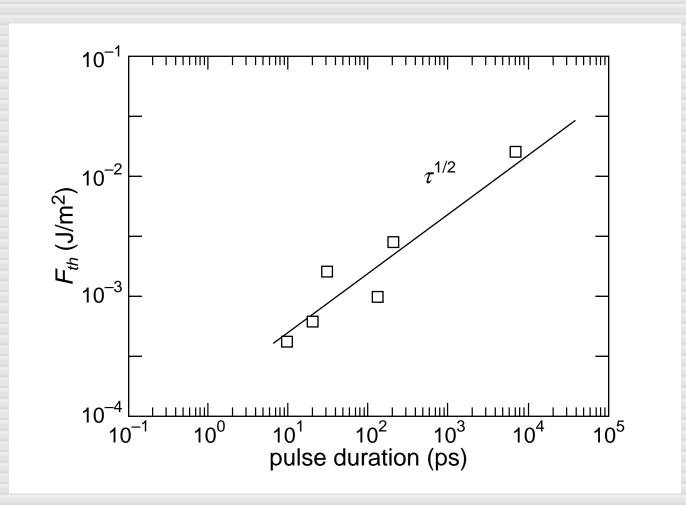
Outline

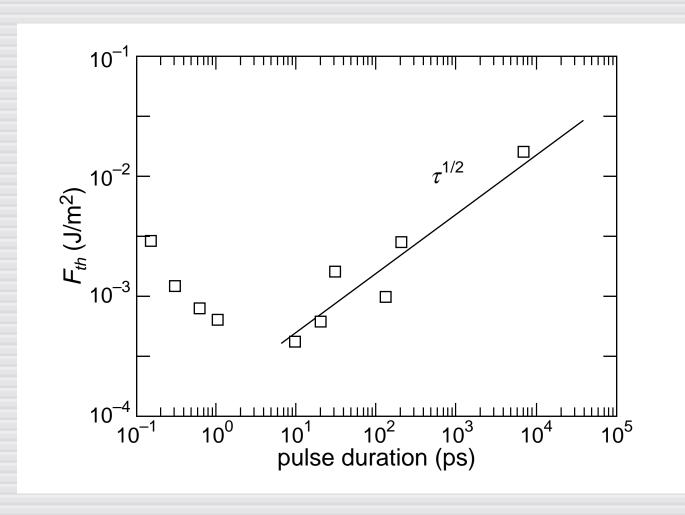
Processing with fs pulses

Role of focusing

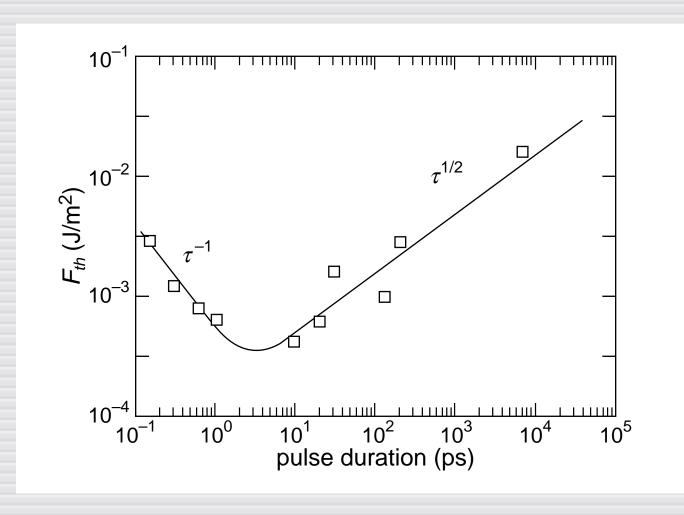
Low-energy processing







Du et al., Appl. Phys. Lett. 64, 3071 (1994)



Du et al., Appl. Phys. Lett. 64, 3071 (1994)

Breakdown threshold and plasma formation

in femtosecond laser-solid interaction

Institut für Laser- und Plasmophysik. Universität Essen, D.45117 Essen, Germany

D. von der Linde and H. Schüler

Combining femtosecond pump-probe techniques with optical microscopy, we have studied laser-induced optical breakdown in optically transparent solids with high temporal and spatial resolution. The threshold of Combining femtosecond pump-probe techniques with optical microscopy, we have studied laser-induced optical breakdown in optically transparent solids with high temporal and spatial resolution. The threshold of laser induced plasma formation has been determined from measurements of the changes of the optical reflectivity associated optical breakdown in optically transparent solids with high temporal and spatial resolution. The threshold of plasma formation has been determined from measurements of the changes of the optical reflectivity associated with the developing plasma. It is shown that plasma generation occurs at the surface. We have observed plasma formation has been determined from measurements of the changes of the optical reflectivity associated. We have observed with the developing plasma. It is shown that plasma generation occurs at the surface. We have observed a remarkable resistance to optical breakdown and material damage in the interaction of femtosecond last with the developing plasma. It is shown that plasma generation occurs at the surface. We have observed a remarkable resistance to optical breakdown and material damage in the interaction of femtosecond laser pulses with bulk optical materials. © 1996 Optical Society of America a remarkable resistance to optical breakdown and material damage in t pulses with bulk optical materials. © 1996 Optical Society of America

J. Opt. Soc. Am. B/Vol. 13, No. 1/January 1996

216

The interaction of intense femtosecond laser pulses with 1. INTRODUCTION solids offers the possibility of producing a new class of plasmas having approximately solid-state density and spatial density scale lengths much smaller than the wavelength of light. These high-density plasmas with extremely sharp density gradients are currently of great the martinularly from the point of view of generatwheet wray pulses. To produce such a Id give from the intensity level formation to the time scale

One of the key points in the research of Bloembergen and his co-workers was the use of very tightly focused laser beams, which allowed them to reach the breakdown threshold of the materials while staying well below the critical power of self-focusing. Self-focusing is one of the major problems in the measurement of bulk breakdown thresholds. In a more recent review Soileau et al.⁵ carefully examined the role of self-focusing in experiments measuring laser-induced breakdown of bulk dielectric materials. They concluded that the breakdown and damage thresholds are also strongly influenced by extrinsic Thus far, the issue of breakdown thresholds in femtosecond laser-solid interaction has barely been touched. man and all carried out laser-induced breakfound silica with pulses ranging in effects. 150 fs. They reported threshold on - of the

D, you doe Limbe and H. Schuler

"... clear evidence that no bulk plasmas ... [and] ... no bulk damage could be produced

Write, Universitie Easter, 13-45-117 First,

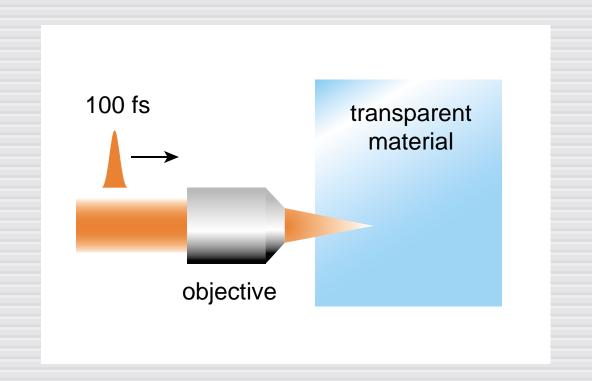
with femtosecond laser pulses."

dama formation has been determined from monostrements of the changes of the Galacies with the desconding placing. It is show that placing generation secure at the intermediation a primaricable residence to achieve because with a material damage in the intermediate with the devolution blacmic. It is shown that plasmic generation secure at the intermition of feature is contribute residence to optical breakdown and waterial domain in the intermition of feature plase with bulk optical materials. I have Optical Society of America optical bacalidaesin in optically transporternt adults with bitly transporternet adults with bitly transporternet and the characteristic of the characteri Communities were were really to the process of the second se Combinition formationers in training product to characteristic a wemarkable resistance to optical breakdown and waterial damage in t police with hole optical materials.

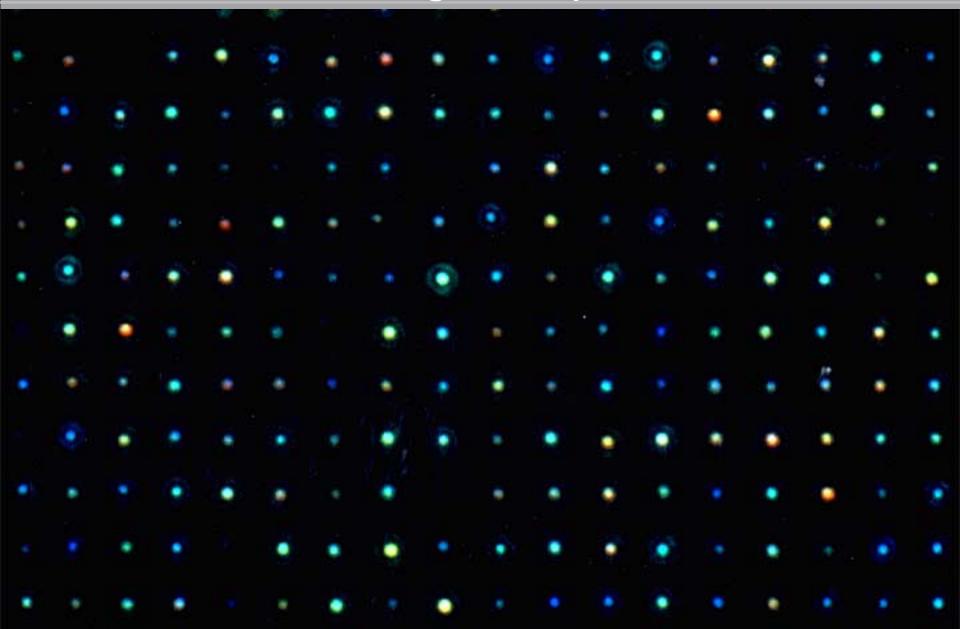
The interaction of intense femtosecond laser pulses with 1. INTRODUCTION solids often the possibility of producing a new class of having approximately solid-ators density and von der Linde, et al., J. Opt. Soc. Am. **13**, 216 (1996)

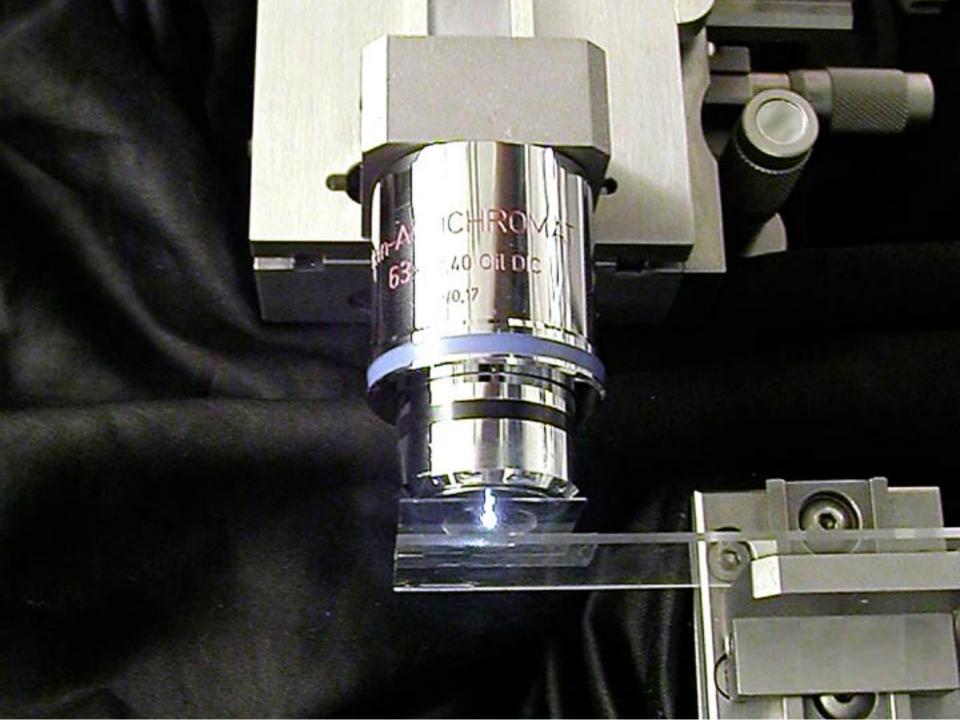
One of the key points in the research of Bloenbergen and his consorkers was the use of very rightly focused laser beams, which allowed them to reach the breakdown threshold of the materials while staying well below the entical power of self-focusing. Self-focusing is one of the nuser problems in the measurement of bulk breakdown thresholds. In a nore recent review Solicito et al.' carefully examined the role of self focusing in experiments measuring laser-induced breakdown of bulk dielectric ma terials. They concluded that the breakdown and dam age thresholds are also strongly influenced by extrinsic Thus far, the issue of breakdown thresholds in femtowershift internetion bas barriy been touched. and the Dard al." carried out laser and order break in the silies with pulses ranging in 150 fs. They reported no blocheniti on

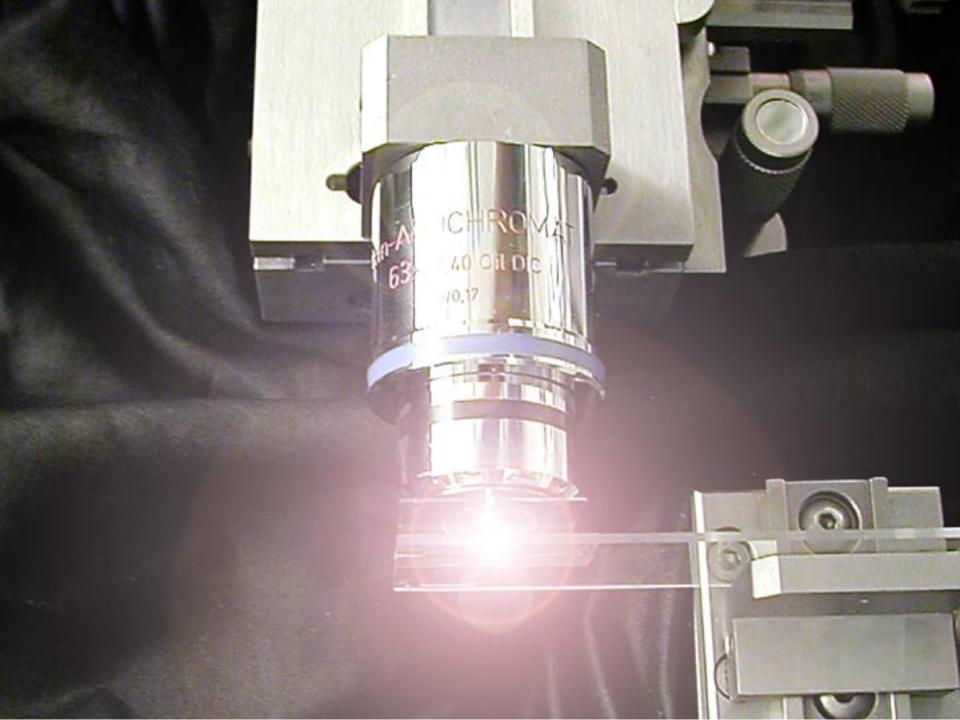
focus laser beam inside material



Glezer, et al., Opt. Lett. 21, 2023 (1996)





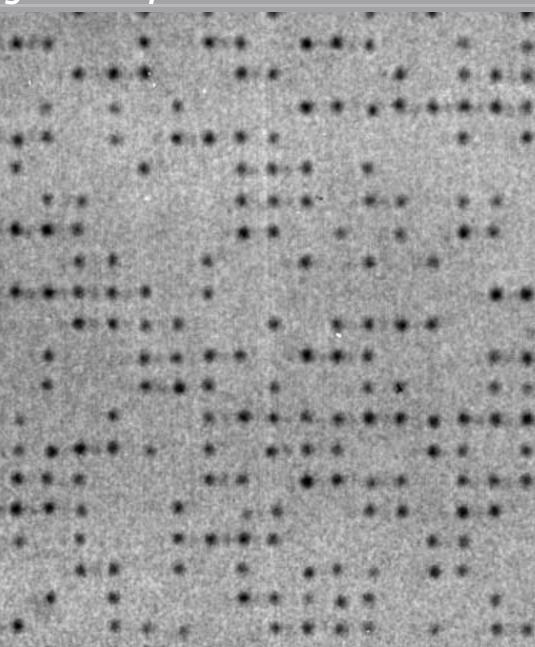


2 x 2 µm array

fused silica, 0.65 NA

0.5 µJ, 100 fs, 800 nm

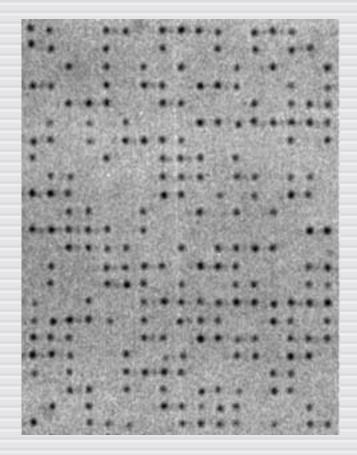




2 x 2 µm array

fused silica, 0.65 NA

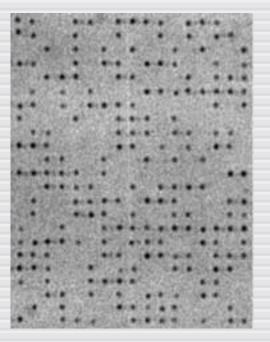
0.5 µJ, 100 fs, 800 nm



2 x 2 µm array

fused silica, 0.65 NA

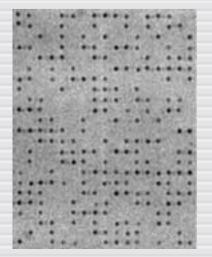
0.5 µJ, 100 fs, 800 nm



2 x 2 µm array

fused silica, 0.65 NA

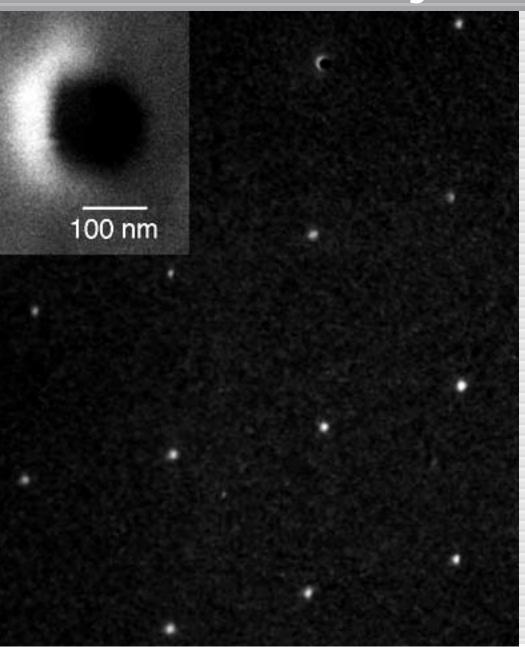
0.5 µJ, 100 fs, 800 nm





100 fs 0.5 μJ

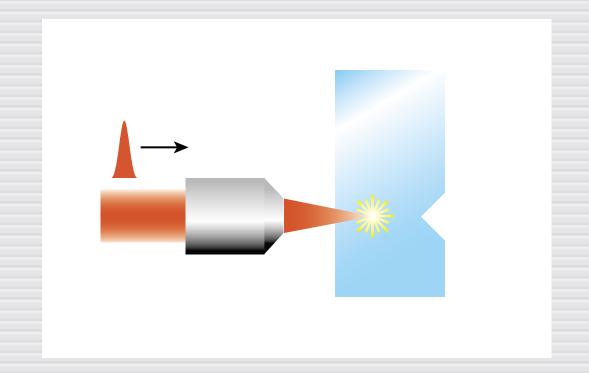
200 ps 9 μJ



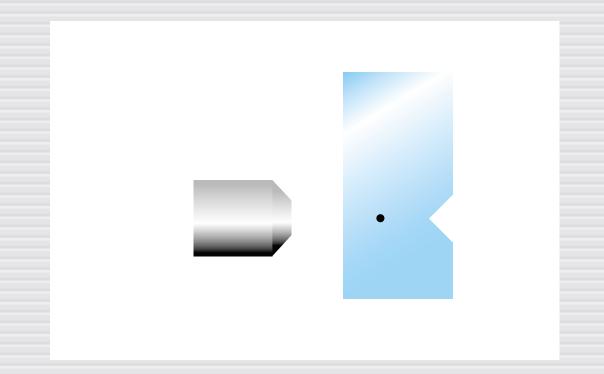
5 x 5 µm array

fused silica, 0.65 NA

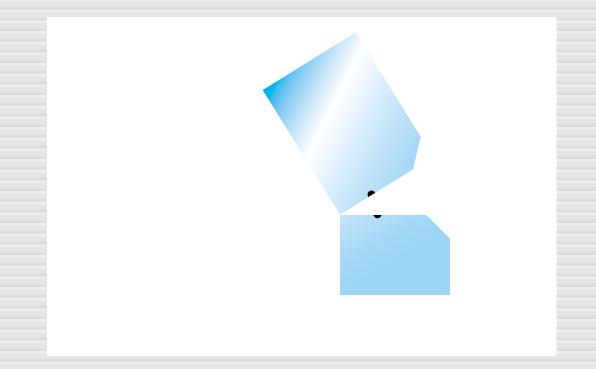
0.5 µJ, 100 fs, 800 nm



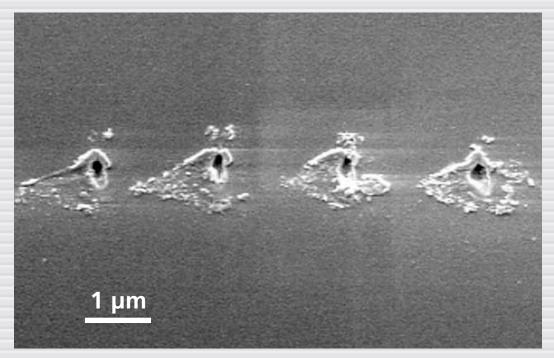
microstructure scribed sample



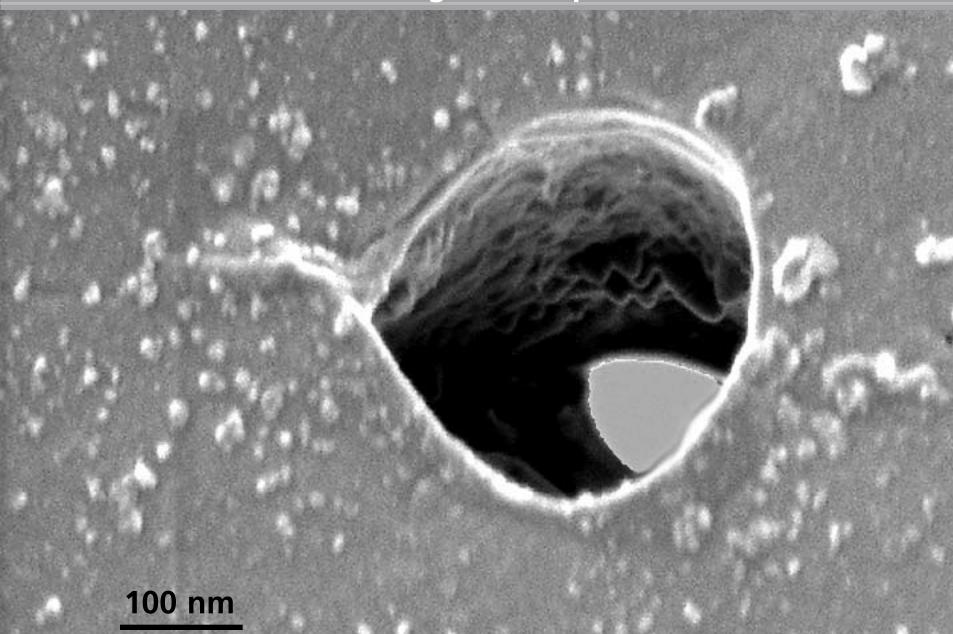
microstructure scribed sample

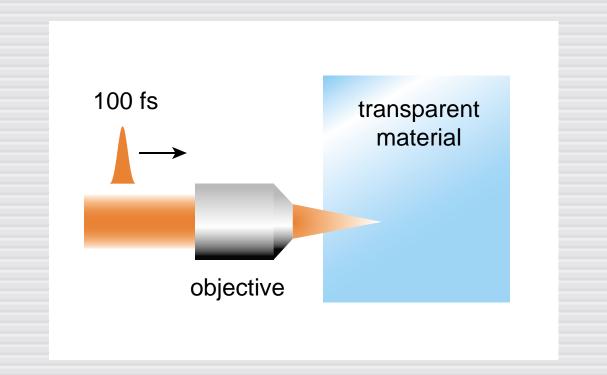


fracture along scribe line

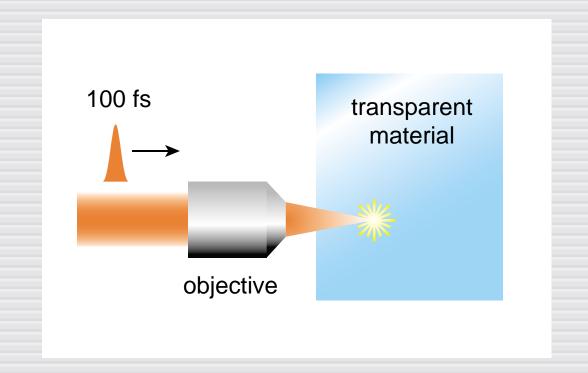


Corning 0211 1.4 NA, 140 nJ

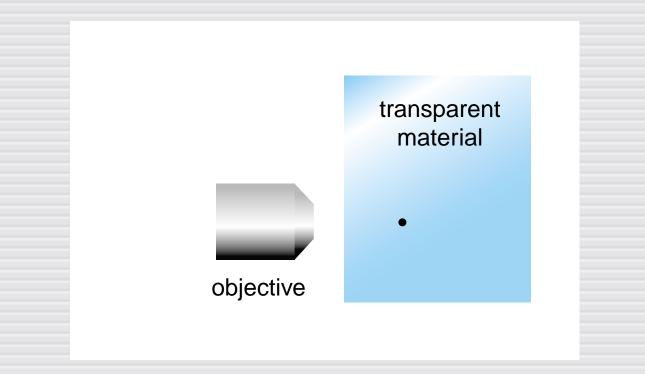




high intensity at focus...

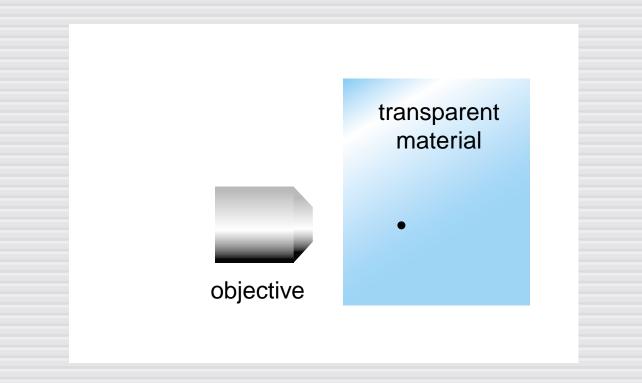


... causes nonlinear ionization...

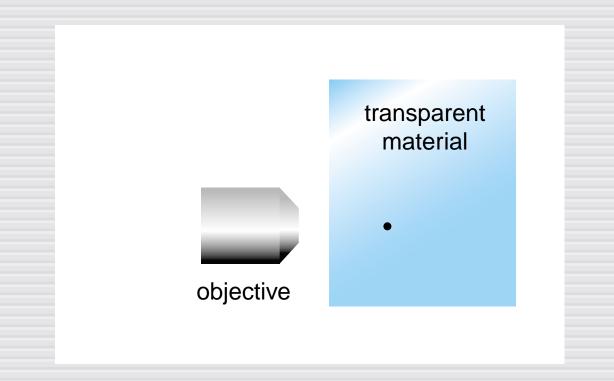


and 'microexplosion' causes microscopic damage

What are the conditions at focus?



What are the conditions at focus?



laser deposits energy in ~1 µm³

What temperature?

What temperature?

$$\Delta E = C_V \rho V \Delta T$$

What temperature?

 $\Delta E = C_V \rho V \Delta T$ $C_V = 0.75 \times 10^3 \,\mathrm{J \, kg^{-1} \, K^{-1}}$ $\rho = 2.2 \times 10^3 \,\mathrm{kg/m^3}$

What temperature?

 $\Delta E = C_V \rho V \Delta T$ $C_V = 0.75 \times 10^3 \,\mathrm{J \ kg^{-1} \ K^{-1}}$ $\rho = 2.2 \times 10^3 \,\mathrm{kg/m^3}$

So, 1 μ J in 1 μ m³ gives

~1,000,000 K!

What pressure?

What pressure?

Treat ionized material as an ideal gas:

$$pV = nRT$$

What pressure?

Treat ionized material as an ideal gas:

$$pV = nRT$$

Gives

$$p = 10$$
 MBar!

So:

microexplosion

T $\approx 1 \text{ MK}$ p $\approx 10 \text{ MBar}$

ho 2.2 × 10³ kg/m³

So:

	microexplosion	sun
Т	≈1 MK	2-5 MK
р	≈10 MBar	
ρ	$2.2 \times 10^3 \mathrm{kg/m^3}$	$0.15 - 150 \times 10^3 \text{kg/m}^3$

So:

	microexplosion	sun
T	≈1 MK	2-5 MK
р	≈10 MBar	
ρ	$2.2 \times 10^3 \mathrm{kg/m^3}$	$0.15 - 150 \times 10^3 \text{kg/m}^3$

creating stellar conditions in lab!

Points to keep in mind:

- fs laser processing works
- focusing very important
- no collateral damage

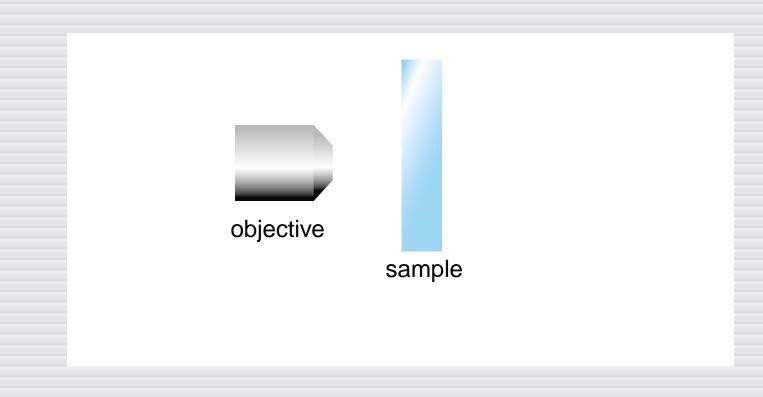
Outline

Processing with fs pulses

Role of focusing

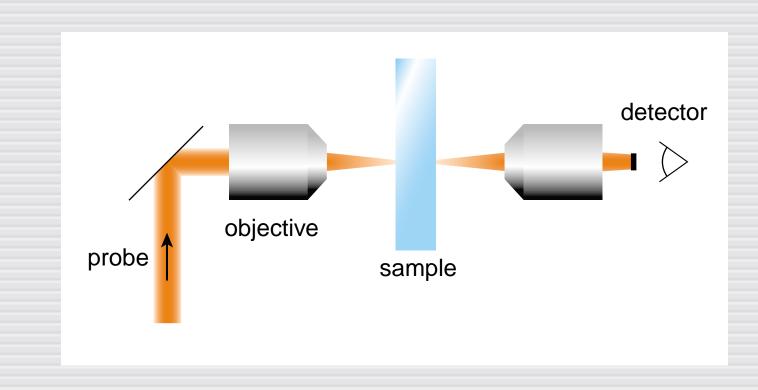


Dark-field scattering



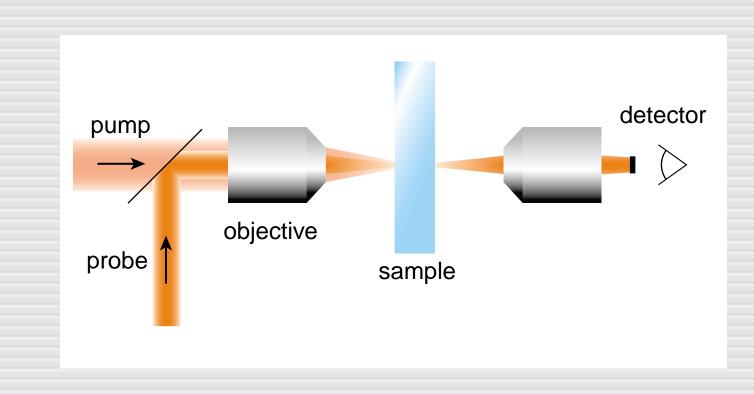


block probe beam...



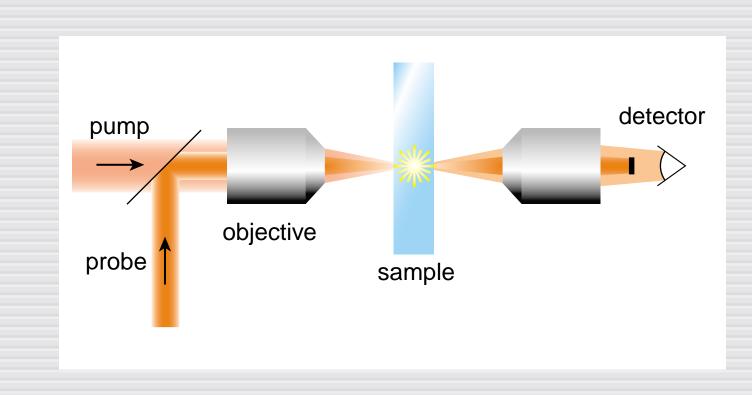


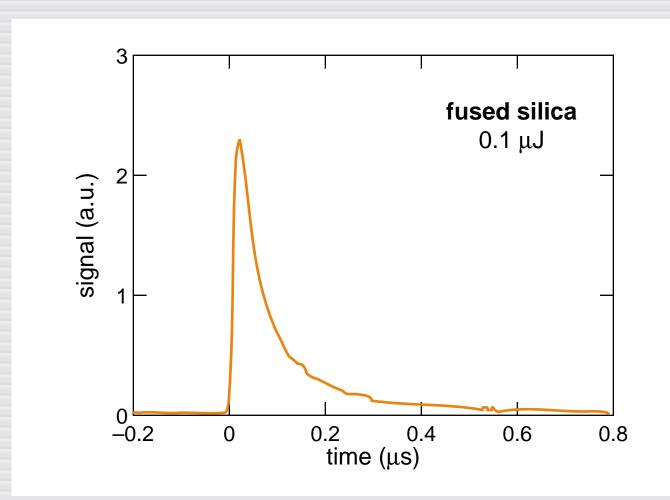
... bring in pump beam...

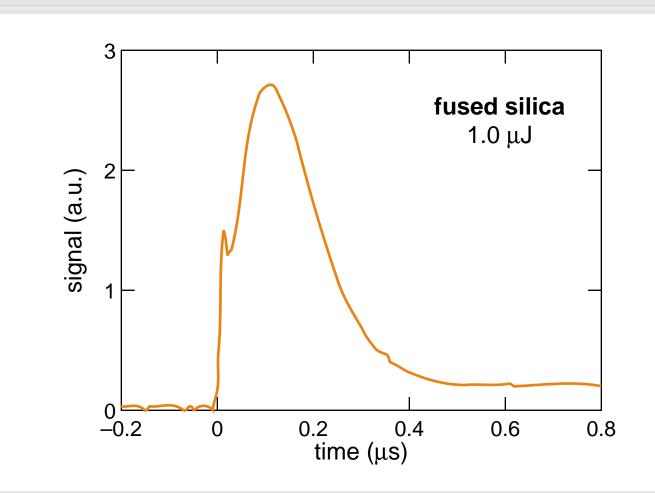


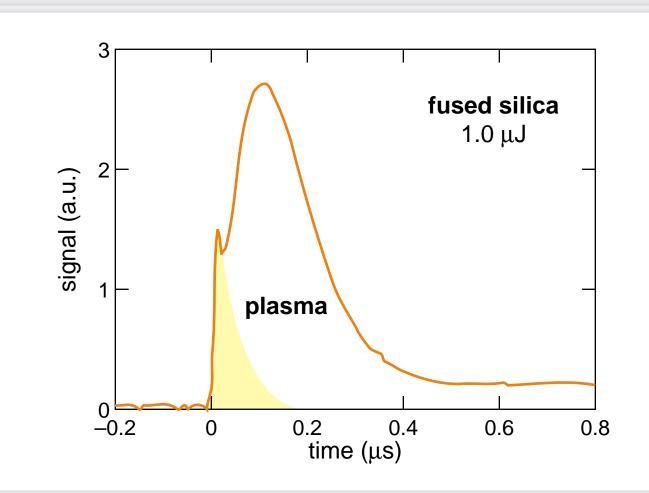


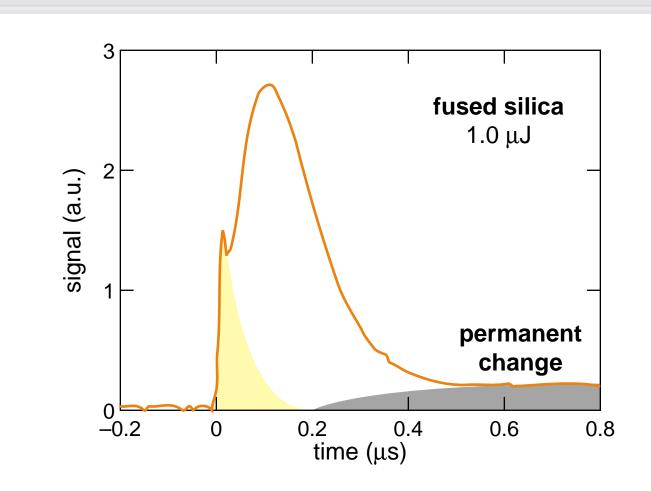
... damage scatters probe beam

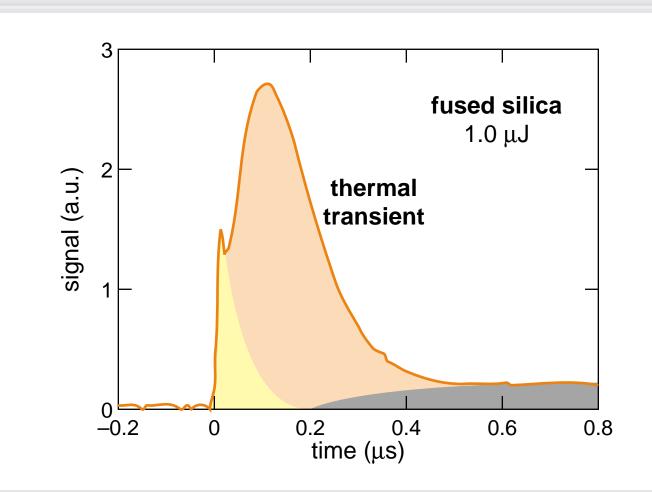




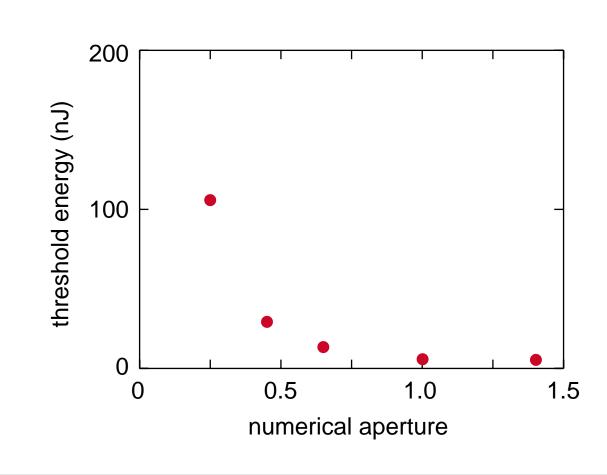


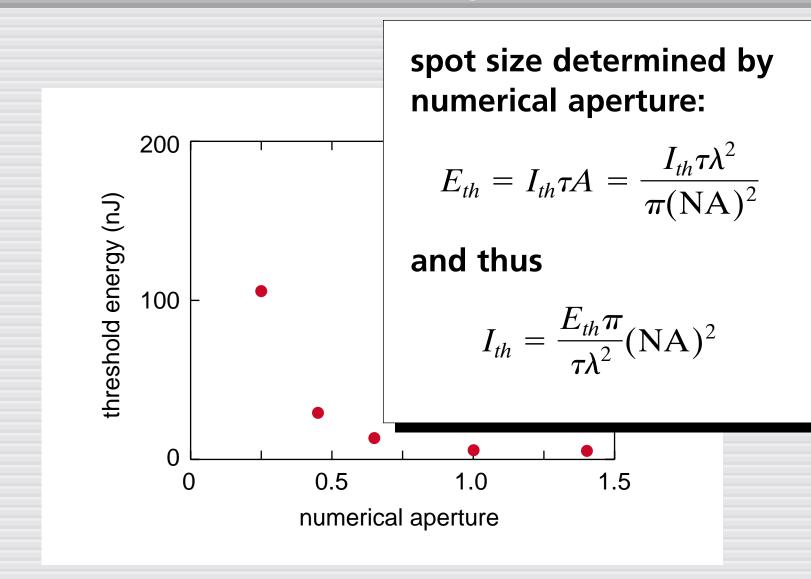




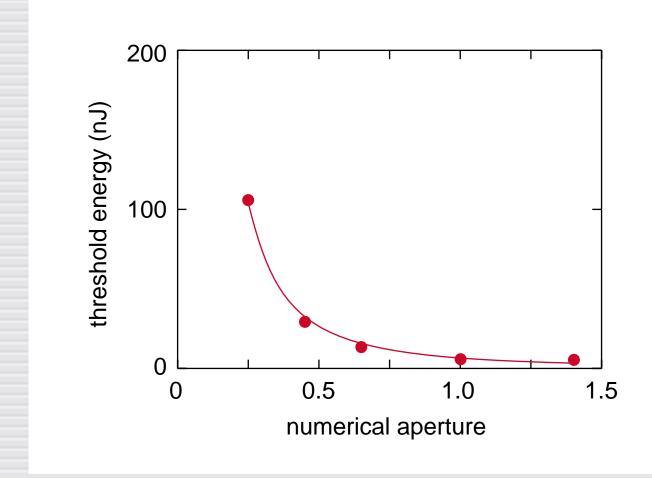


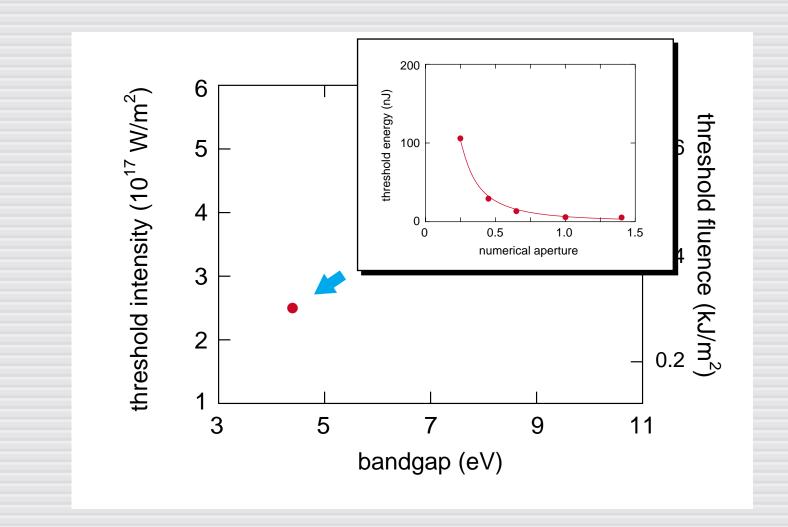
vary numerical aperture in Corning 0211



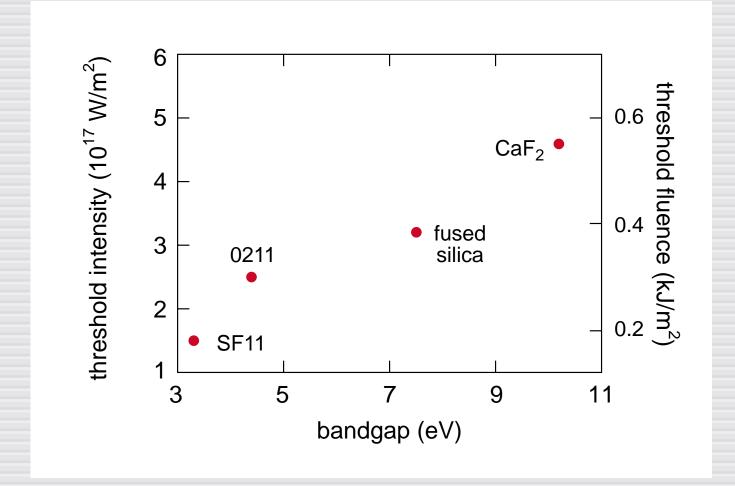


fit gives threshold intensity: $I_{th} = 2.5 \times 10^{17} \text{ W/m}^2$

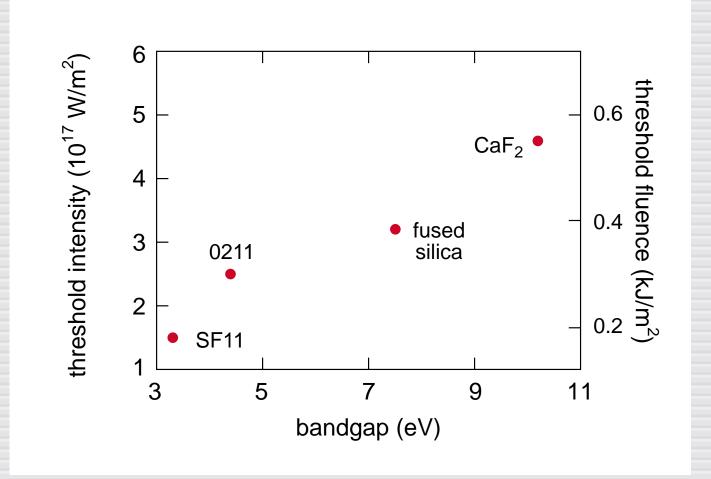




vary material...



threshold varies with bandgap



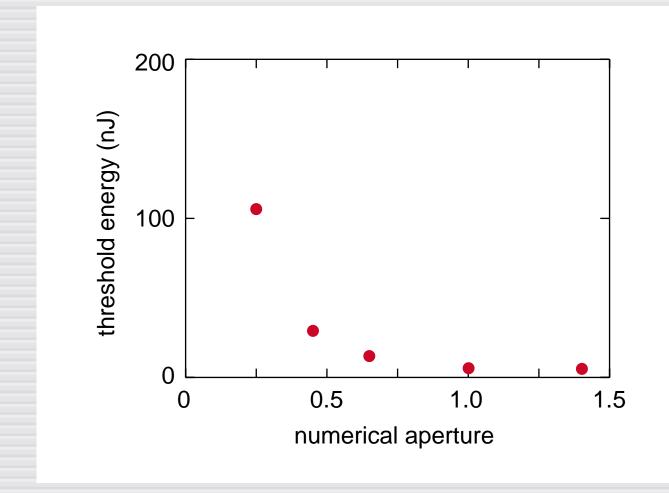
Points to keep in mind:

- threshold critically dependent on NA
- surprisingly little material dependence
- avalanche ionization important

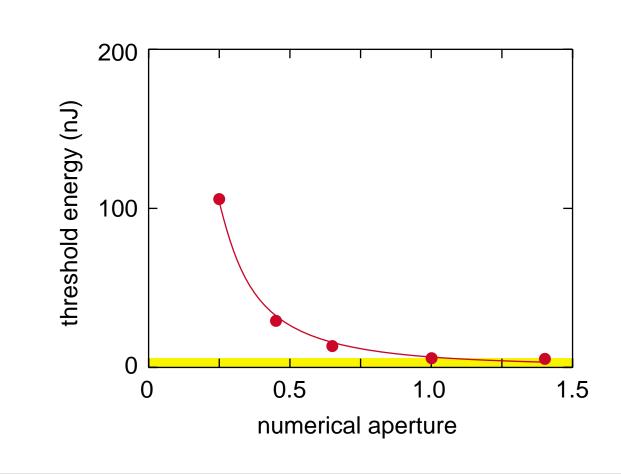
Outline

- Processing with fs pulses
 - Role of focusing
 - Low-energy processing

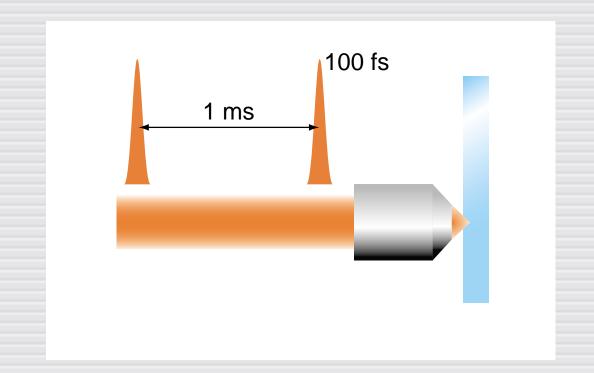
threshold decreases with increasing numerical aperture



less than 10 nJ at high numerical aperture!

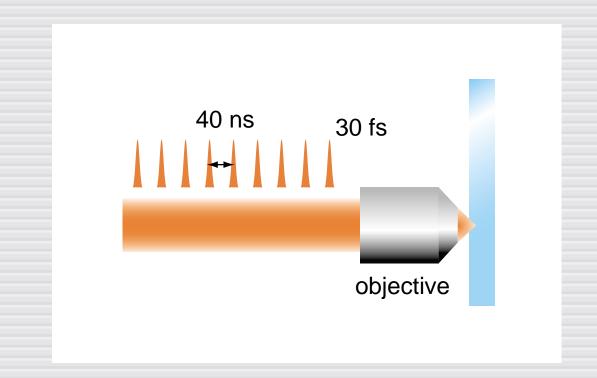


amplified laser

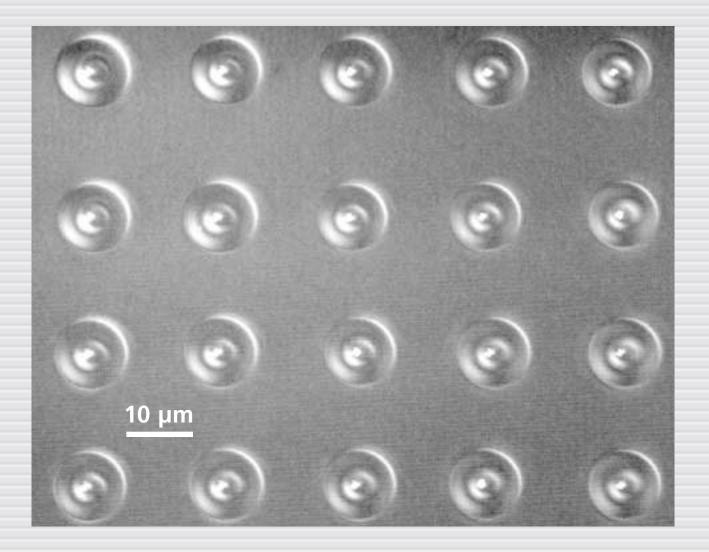


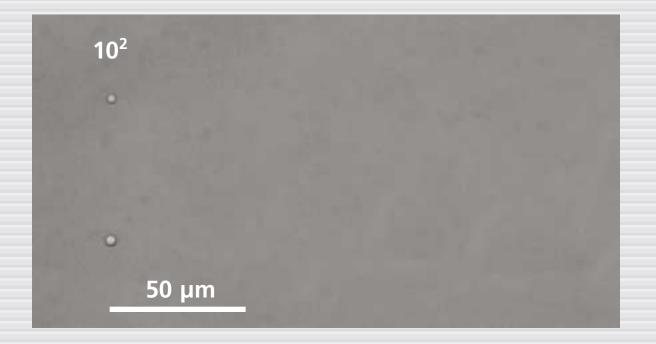
heat-diffusion time: $\tau_{diff} \approx 1 \ \mu s$

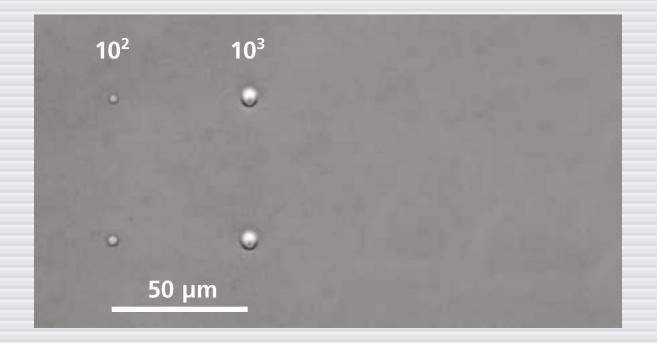
long-cavity Ti:sapphire oscillator

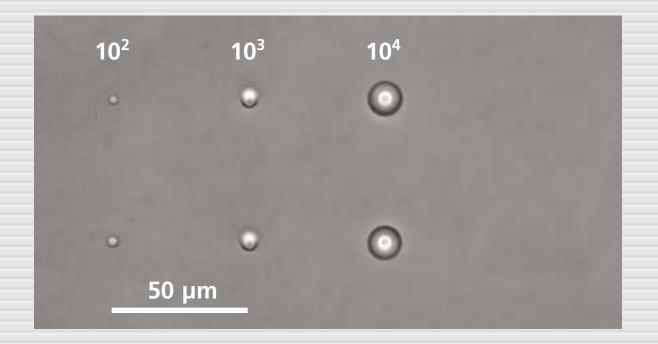


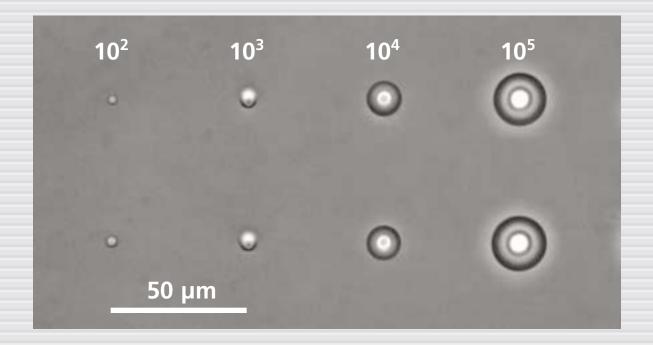
heat-diffusion time: $\tau_{diff} \approx 1 \ \mu s$

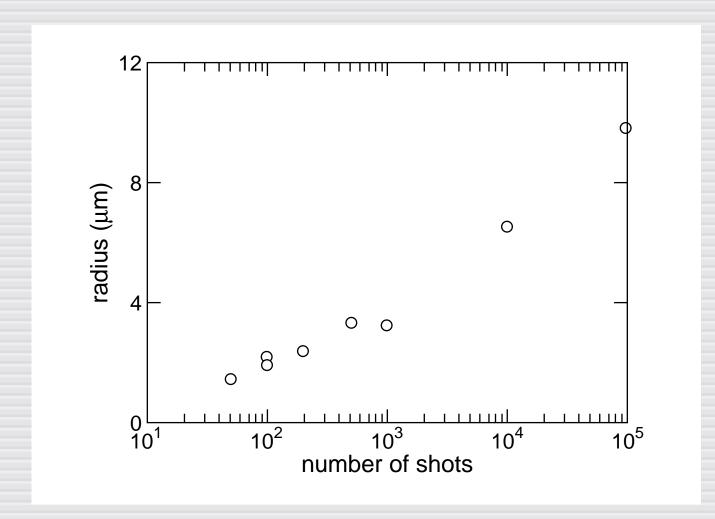




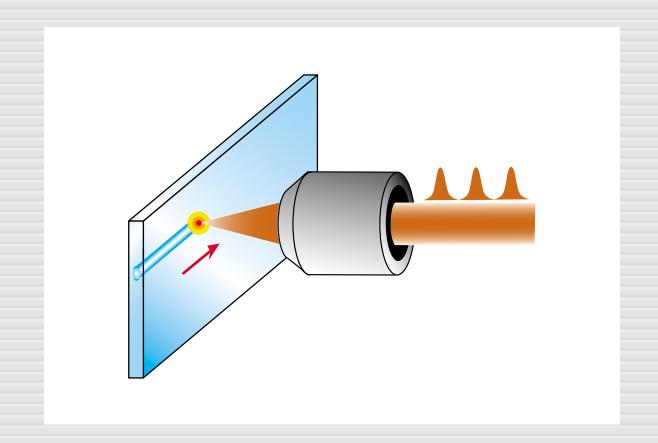




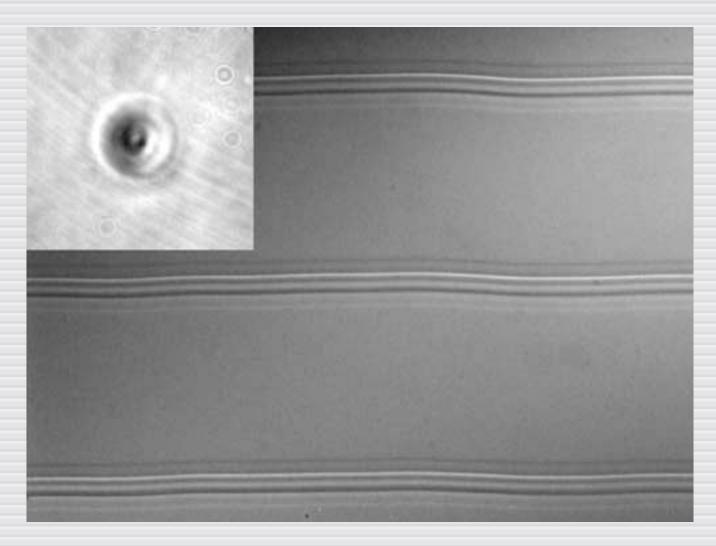




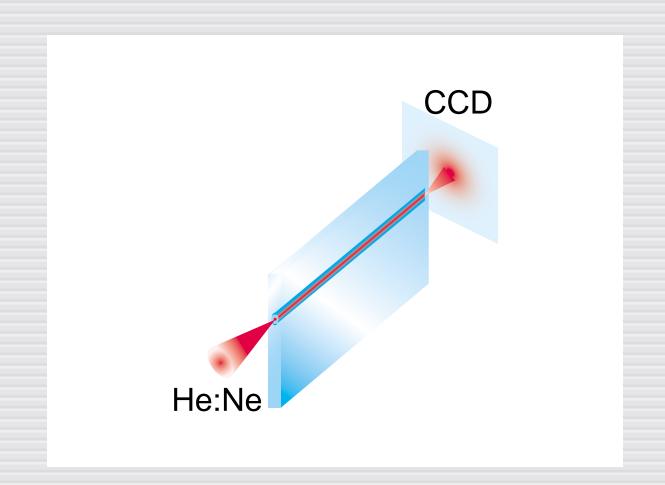
waveguide machining



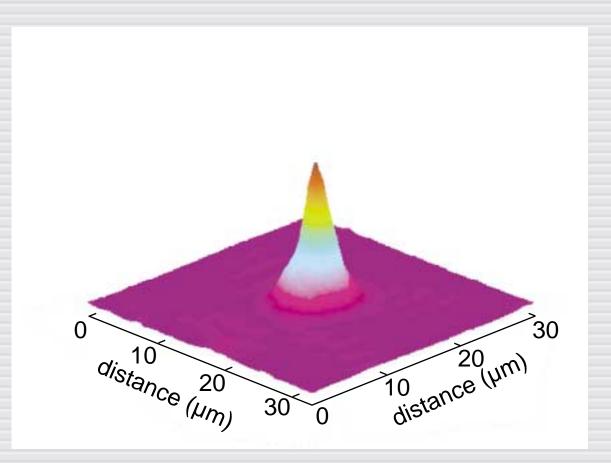
waveguide machining



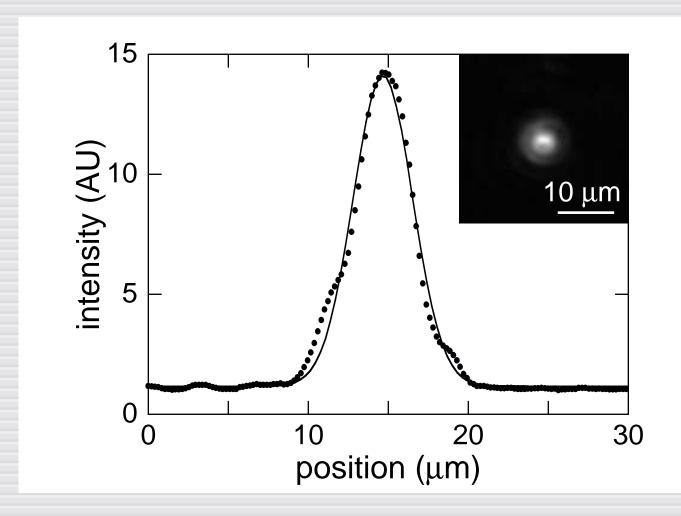
waveguide mode analysis



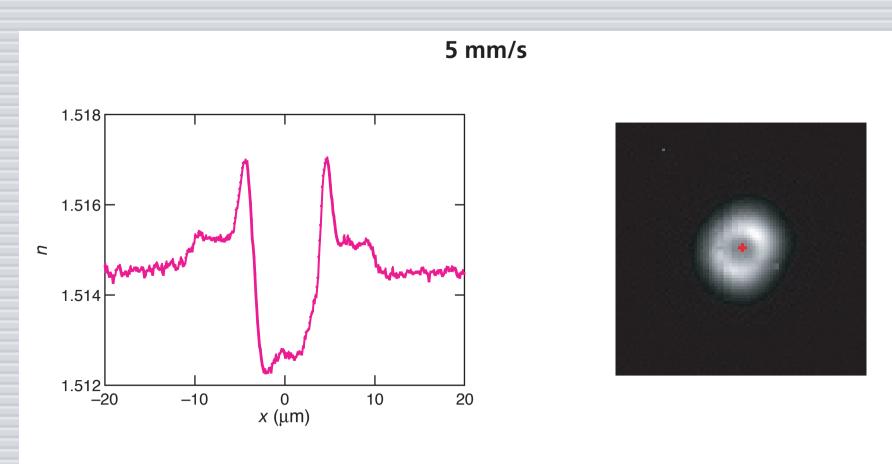
near field mode



near field mode

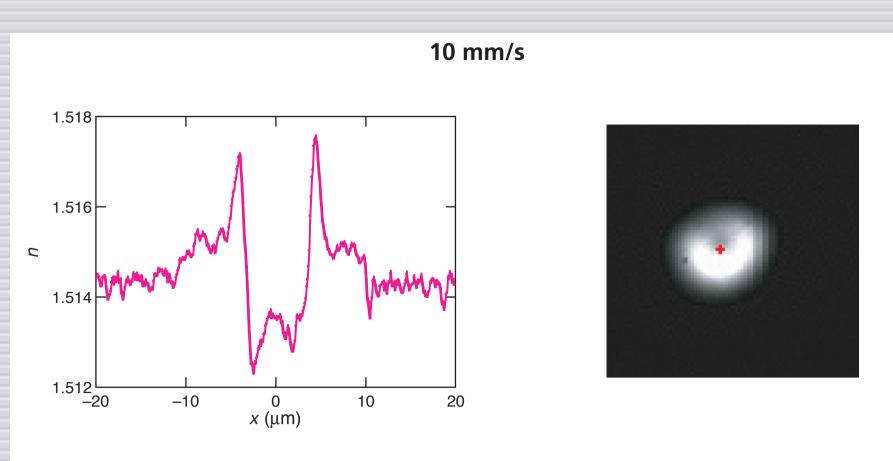


refractive index profiles and near field mode at 633 nm



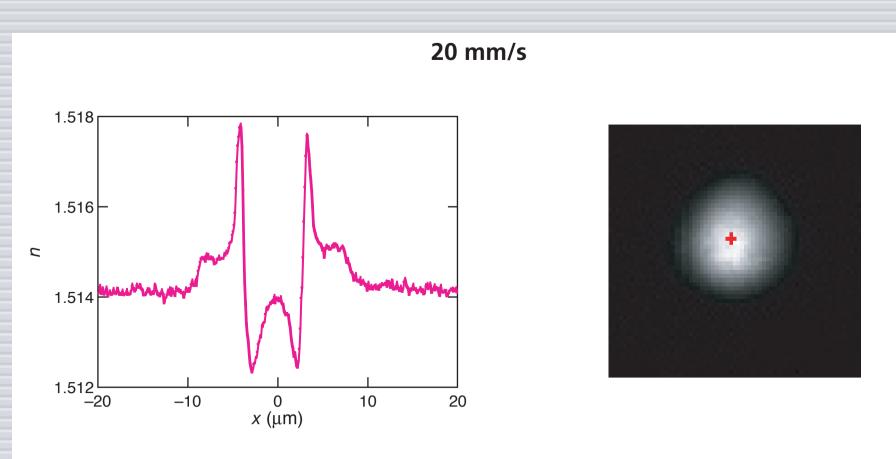
Sagitta, Inc.

refractive index profiles and near field mode at 633 nm

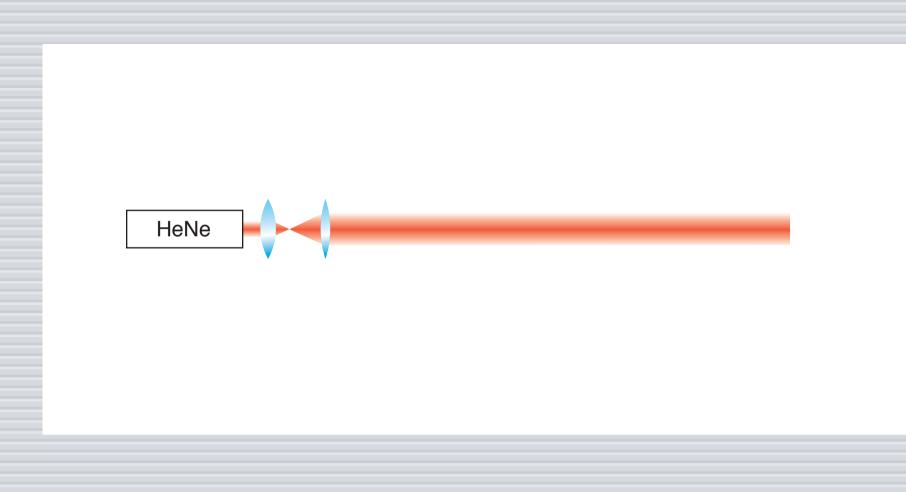


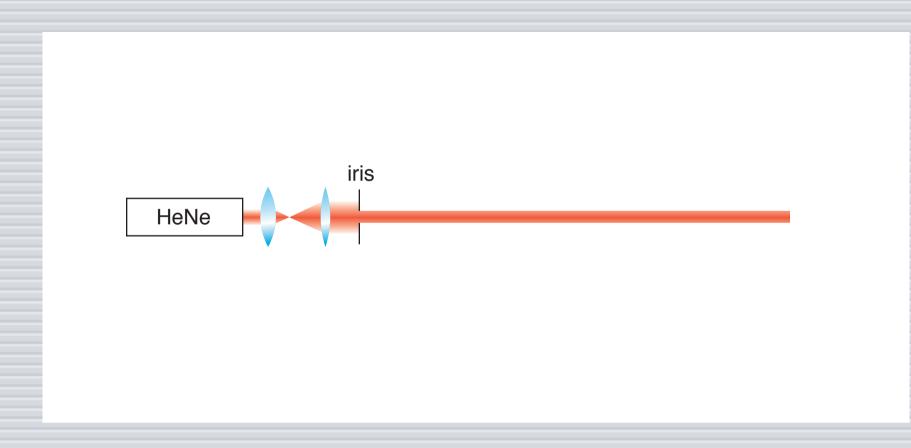
Sagitta, Inc.

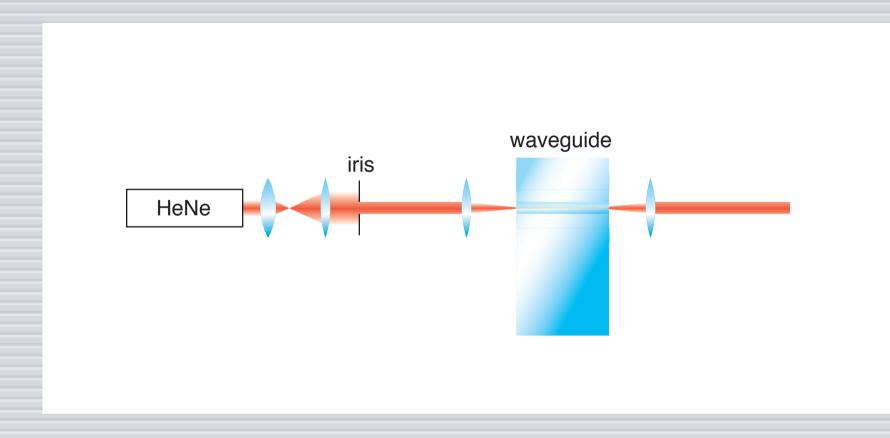
refractive index profiles and near field mode at 633 nm

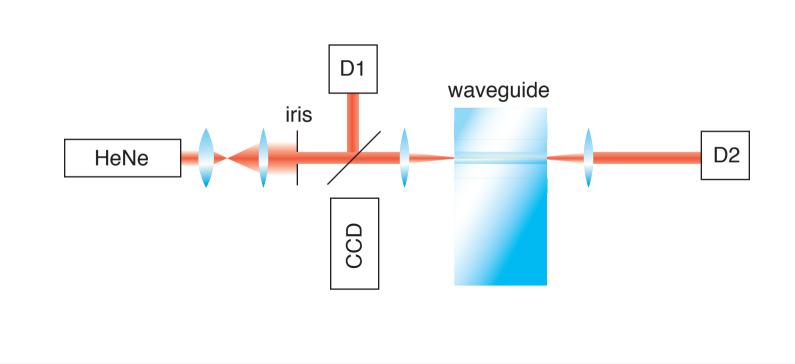


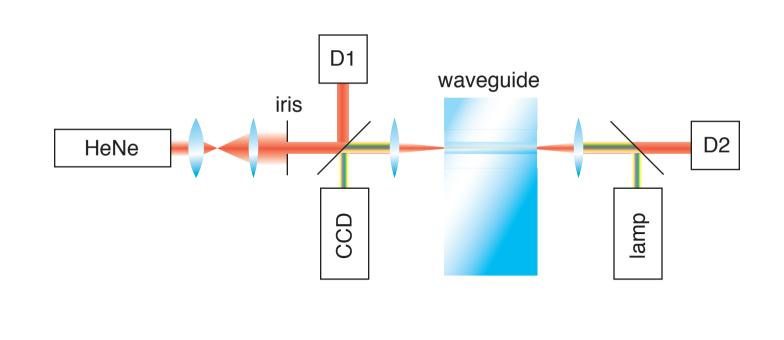
Sagitta, Inc.







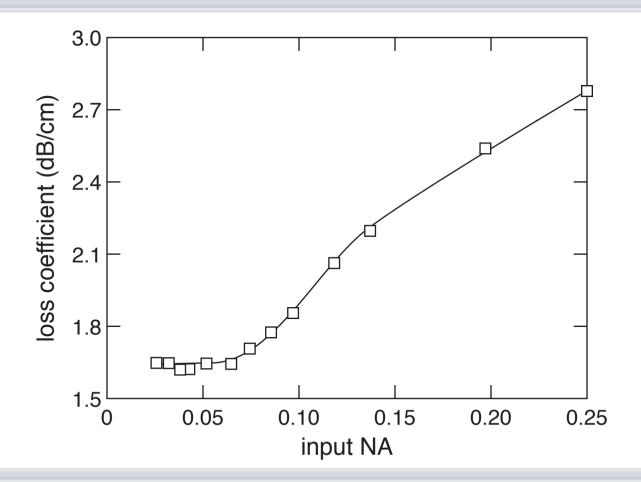


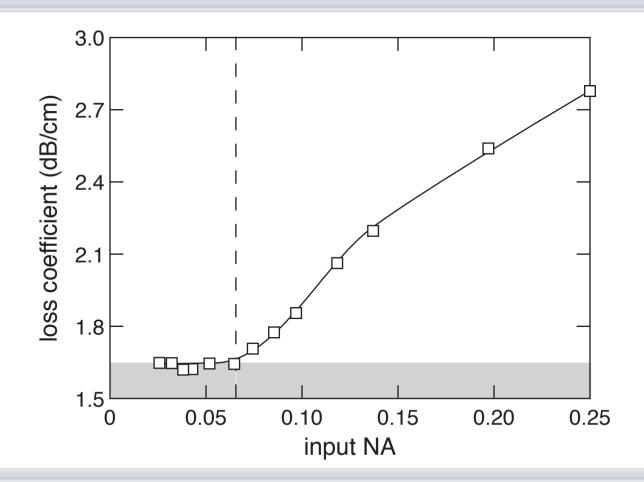


▶ at low NA: 1.6 dB/cm < loss < 3.2 dB/cm

▶ at low NA: 1.6 dB/cm < loss < 3.2 dB/cm

Iosses mostly due to scattering





$$NA = \sqrt{n_1^2 - n_2^2} = 0.065$$

$$NA = \sqrt{n_1^2 - n_2^2} = 0.065$$

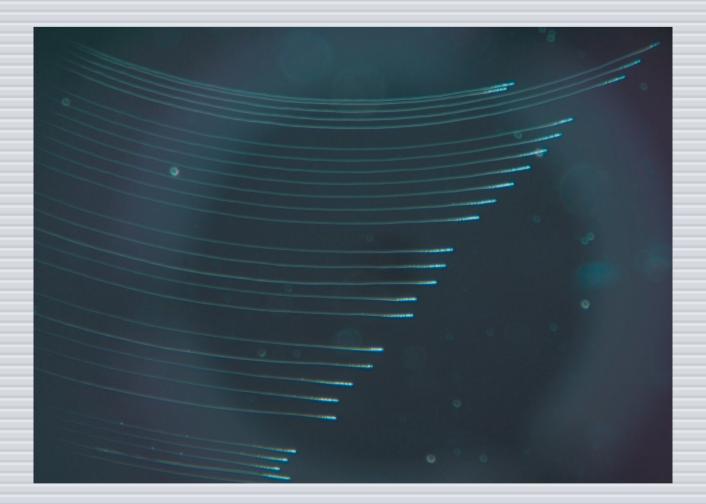
$$n_2 = 1.52$$

$$NA = \sqrt{n_1^2 - n_2^2} = 0.065$$

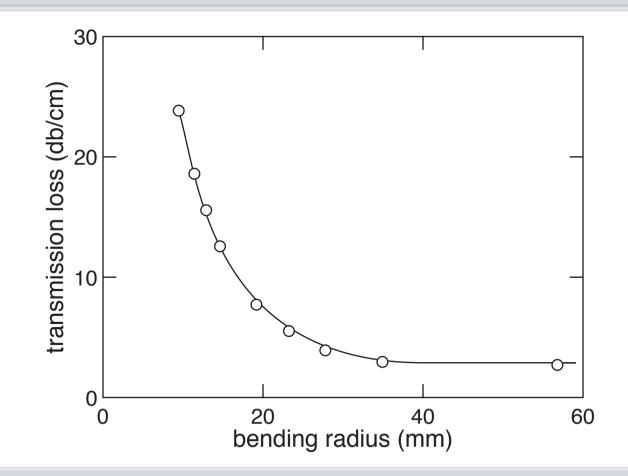
$$n_2 = 1.52$$

$$\Delta n = 1.4 \times 10^{-3}$$

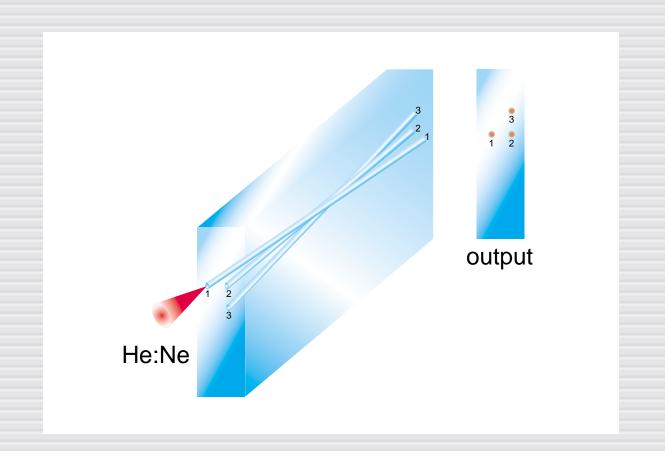
curved waveguides



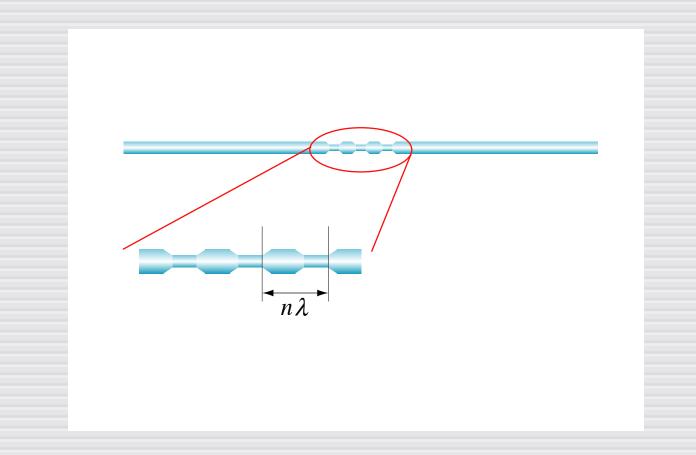
curved waveguides



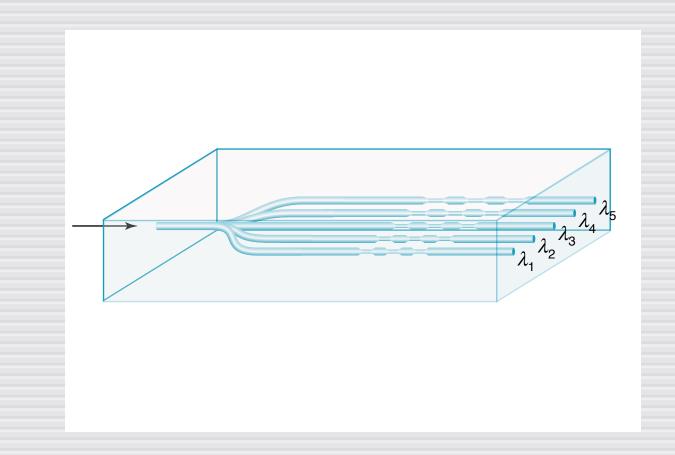
3D wave splitter



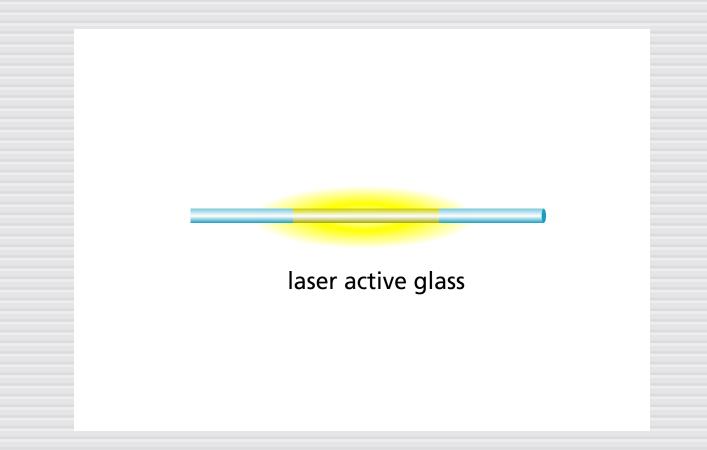
Bragg grating



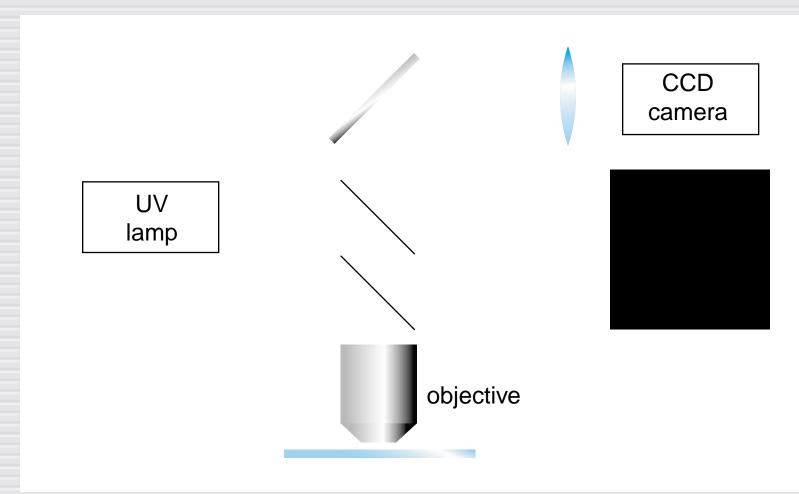
Bragg grating



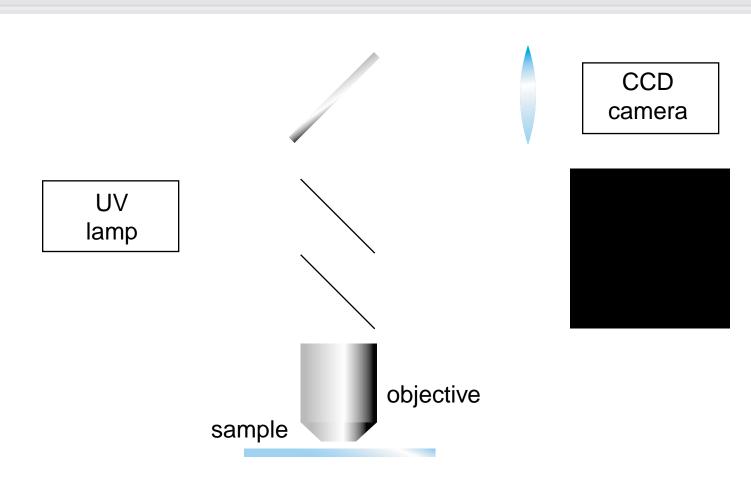
monolithic amplifier



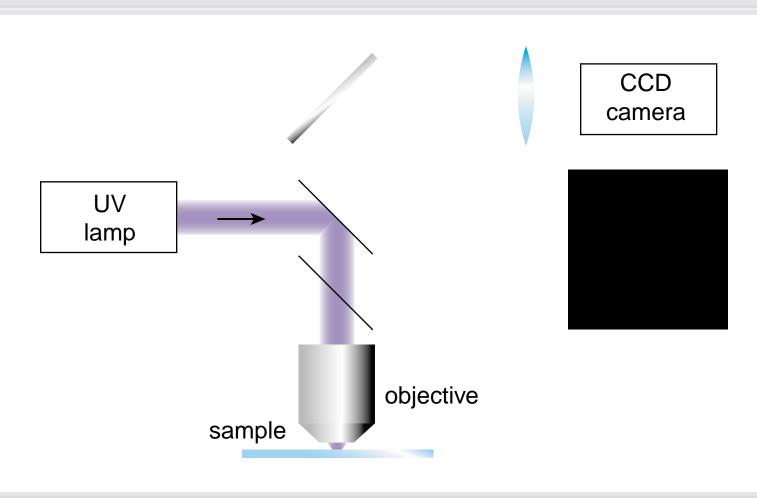
epi-fluorescence microscope



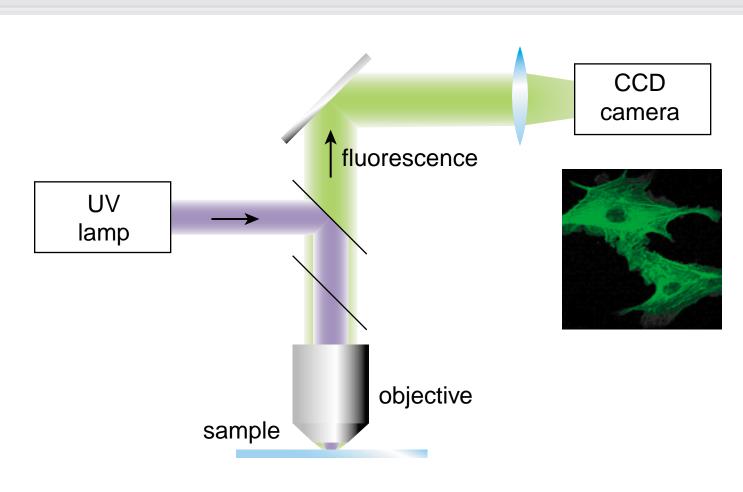
mount fluorescently tagged sample



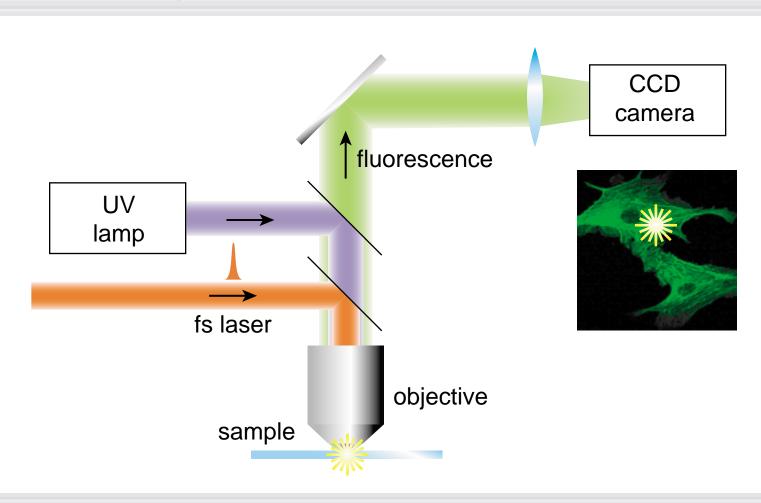
UV illumination...

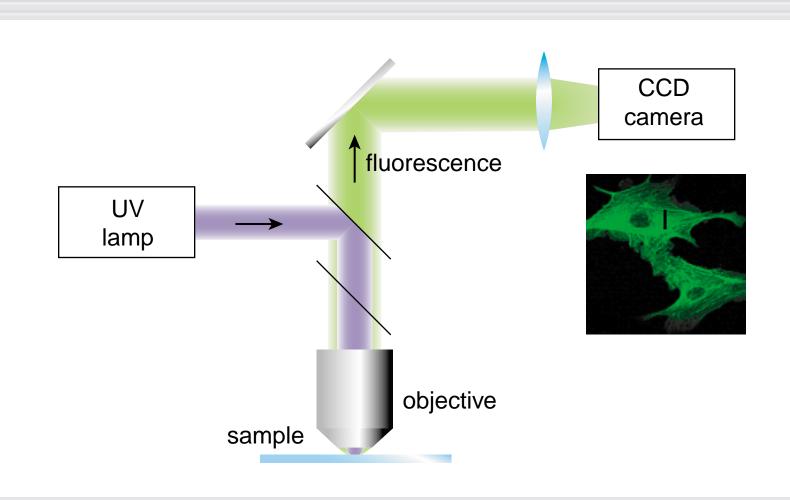


... causes fluorescence



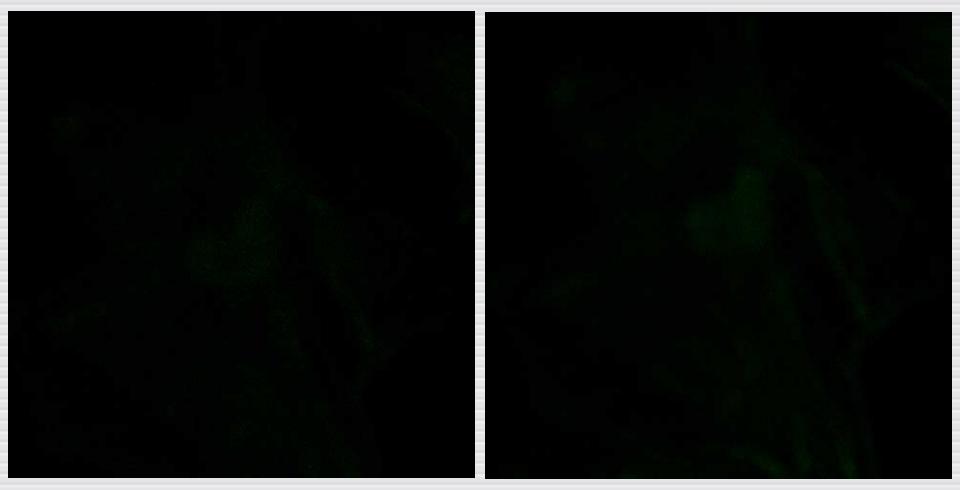
process with fs laser beam





before

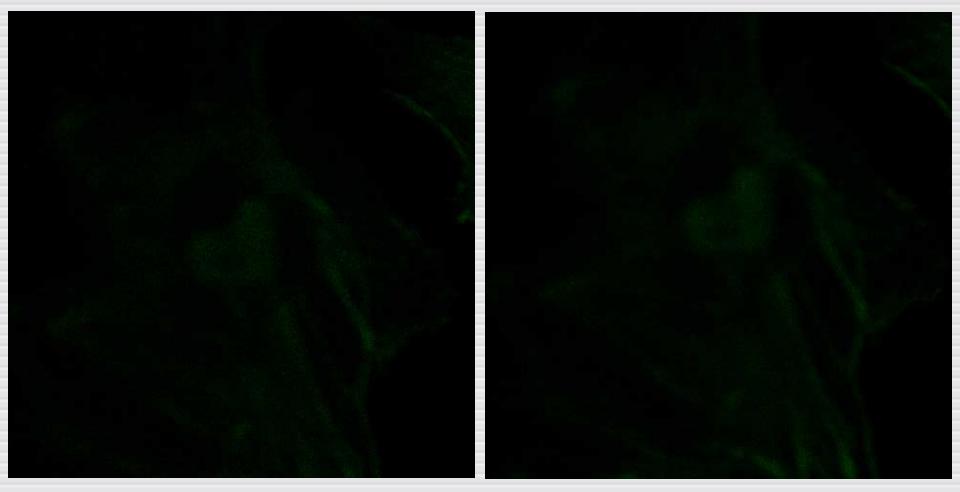




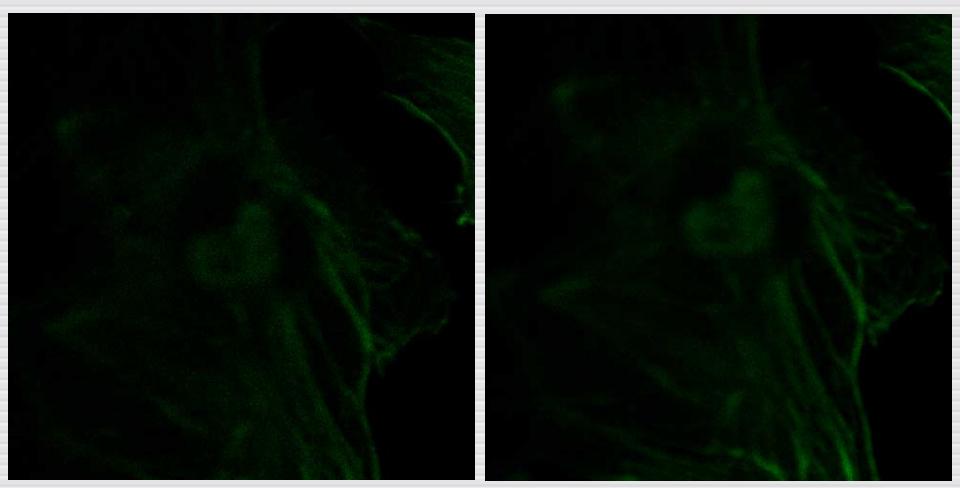
examine in confocal microscope

before

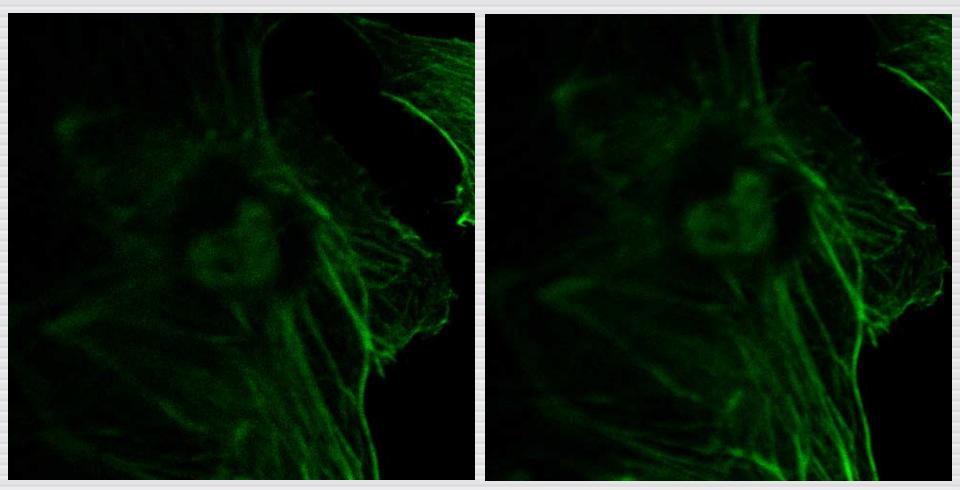




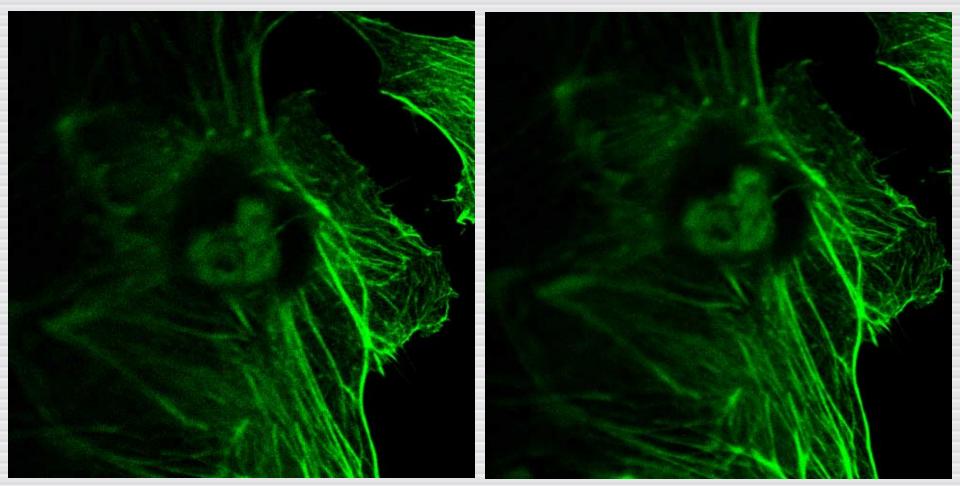
before



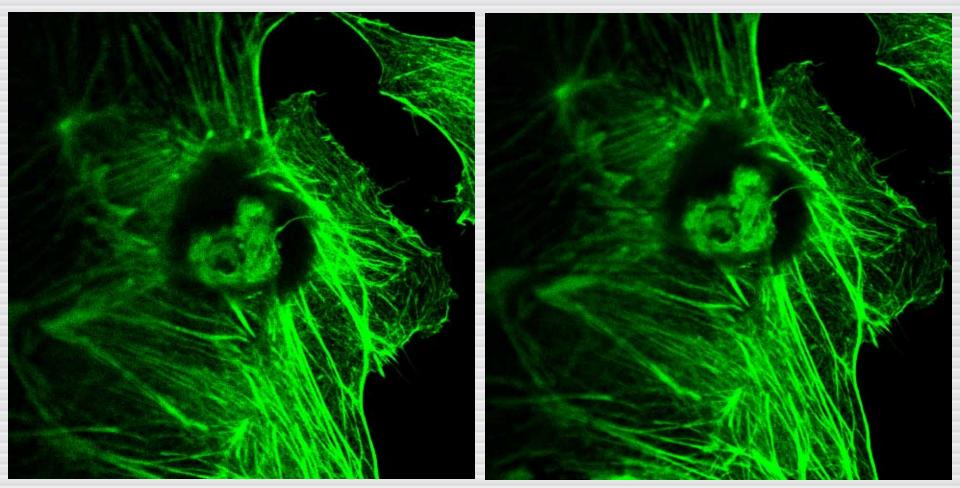
before



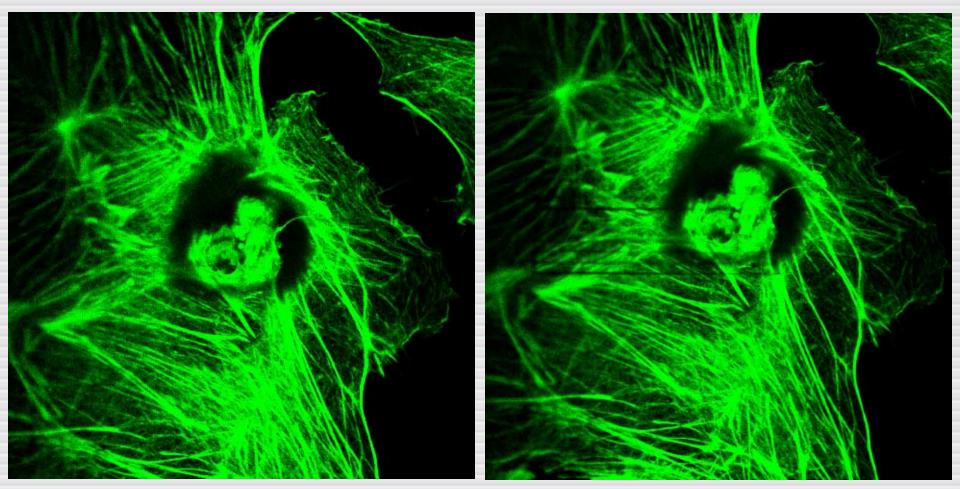




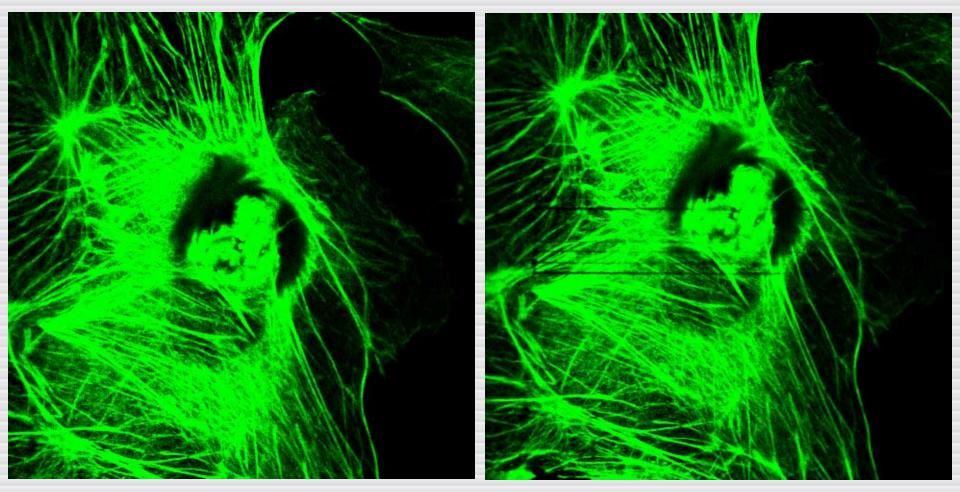
before



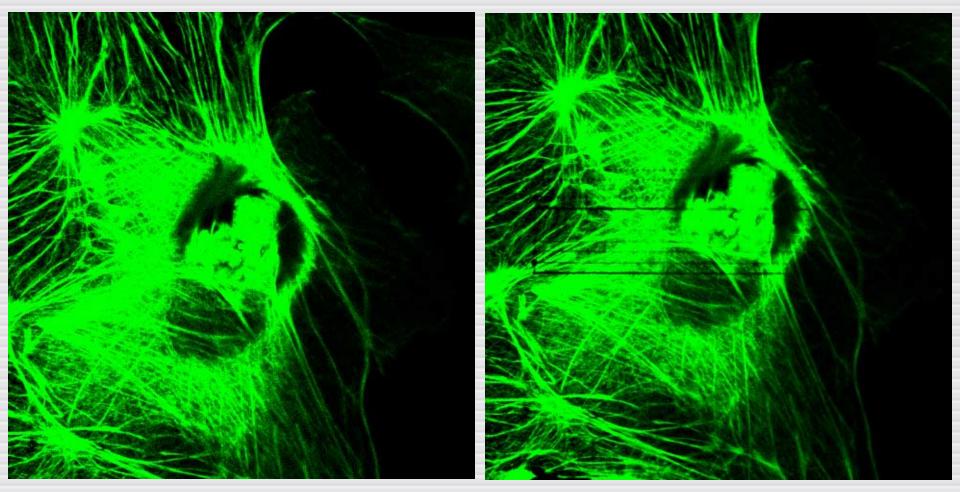
before



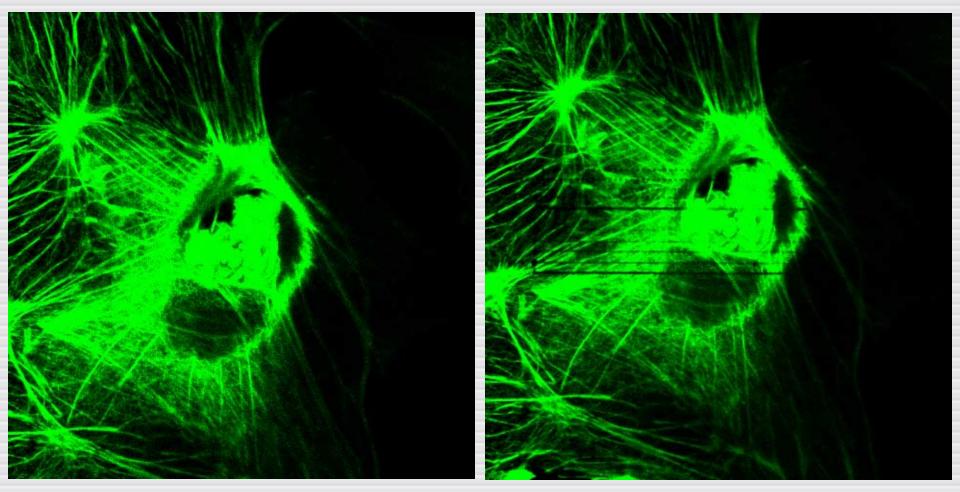
before



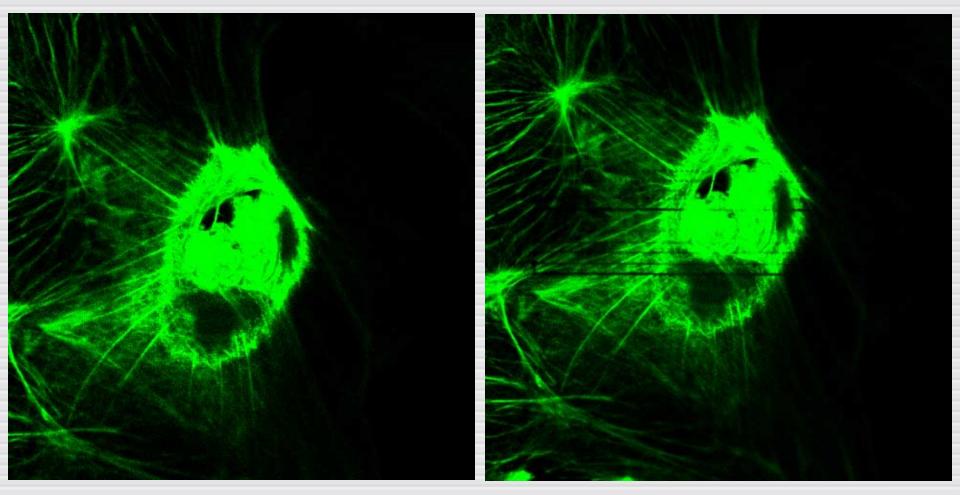
before



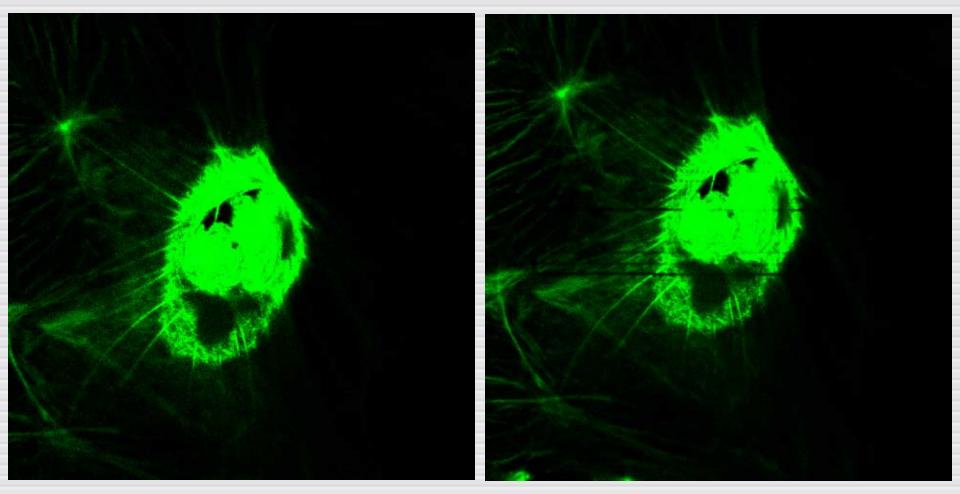
before



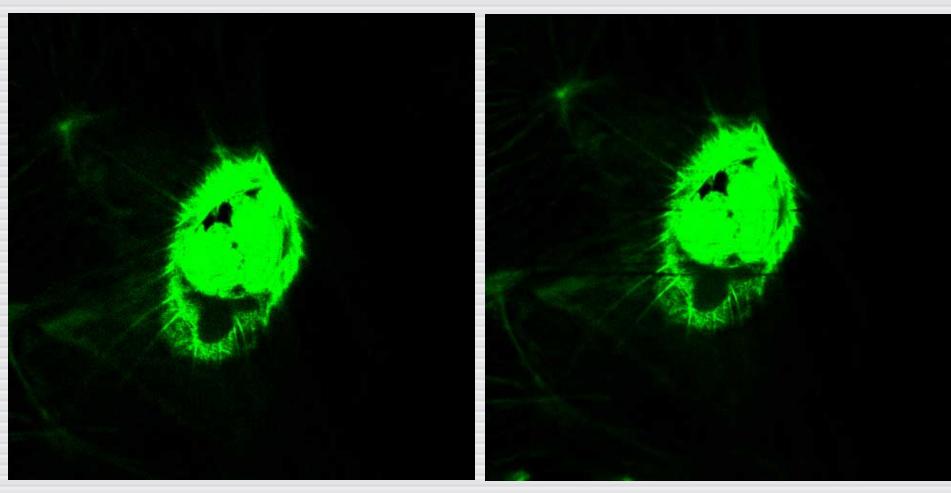
before

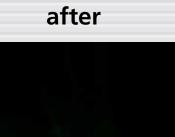


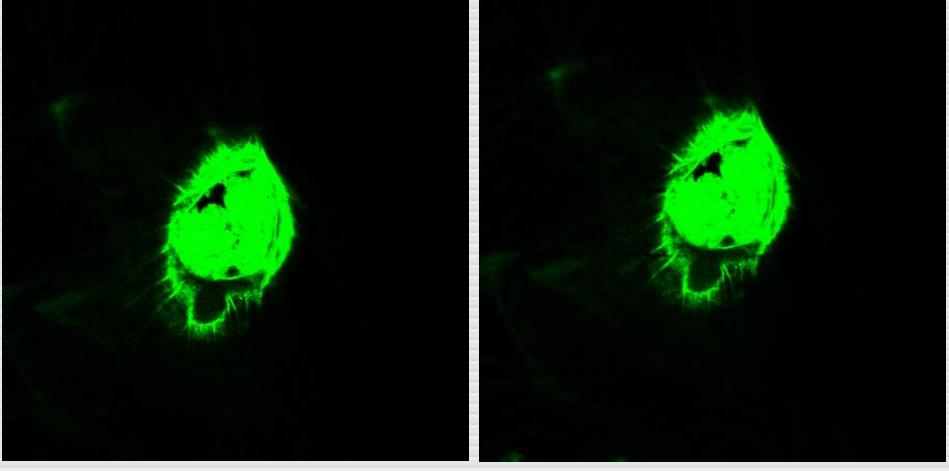
before



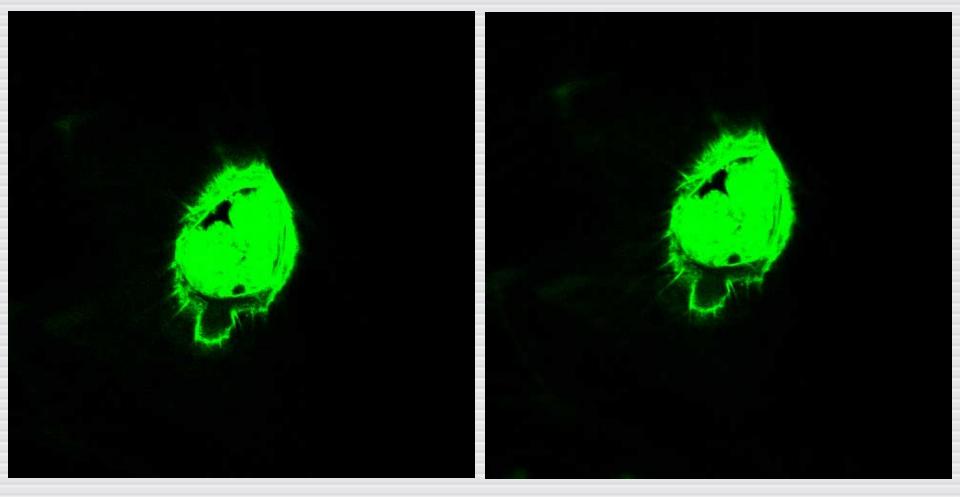
before



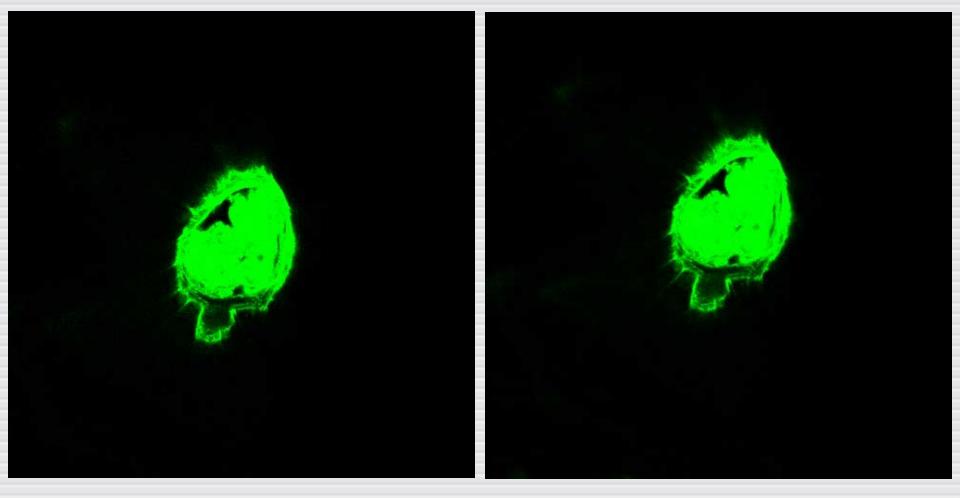




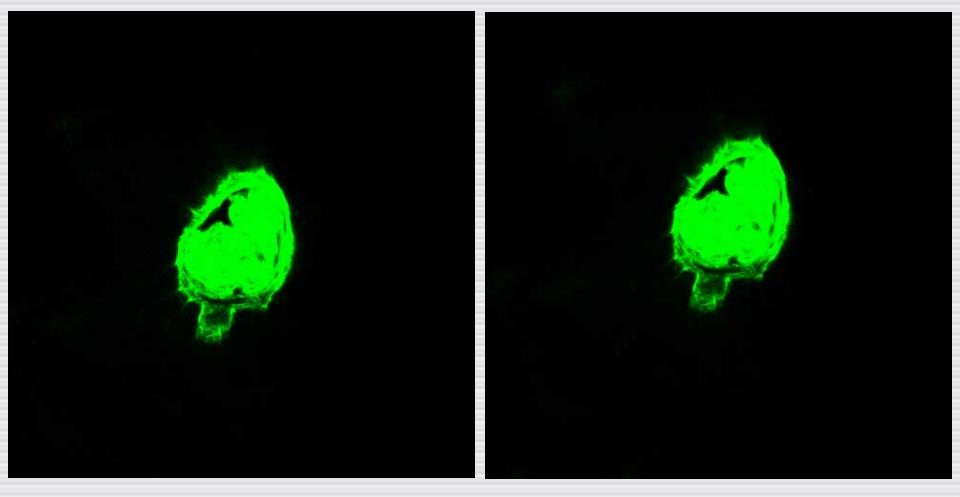


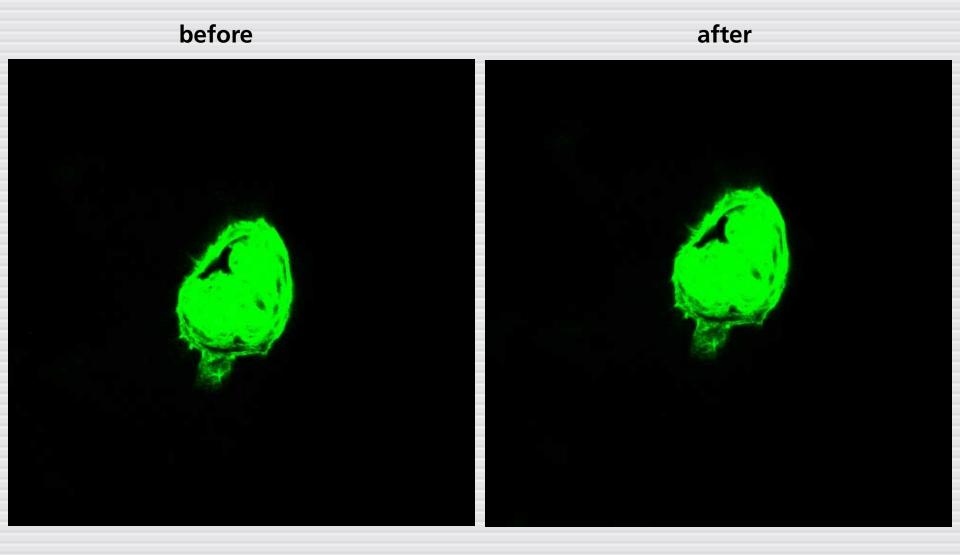


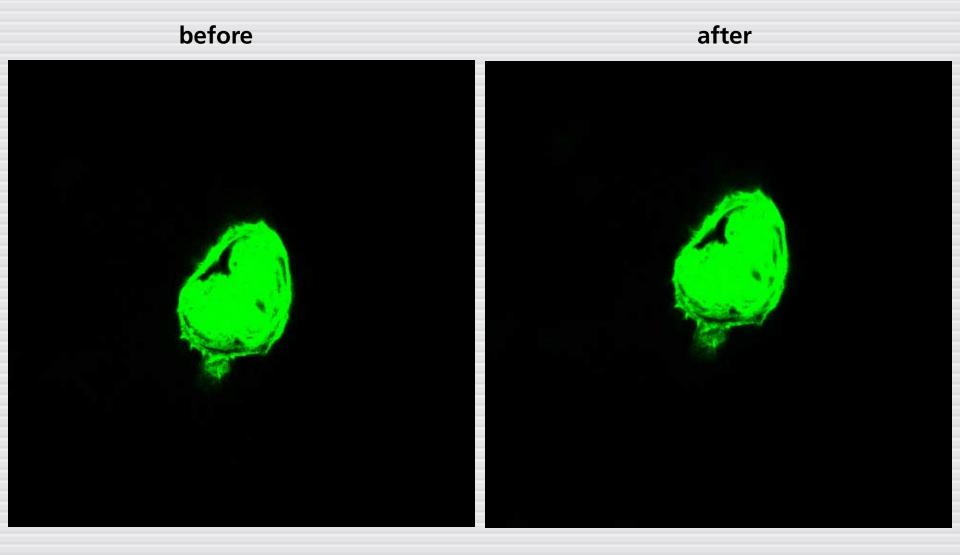


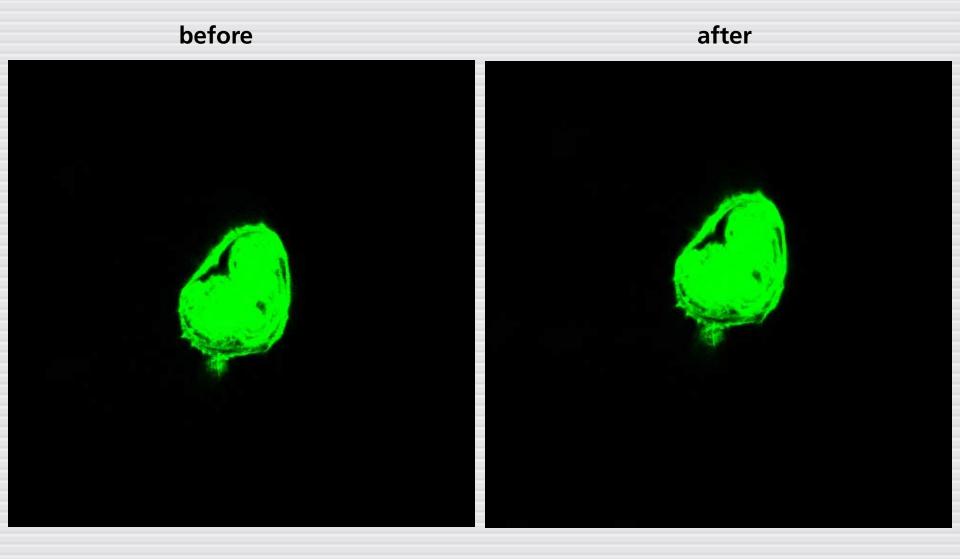


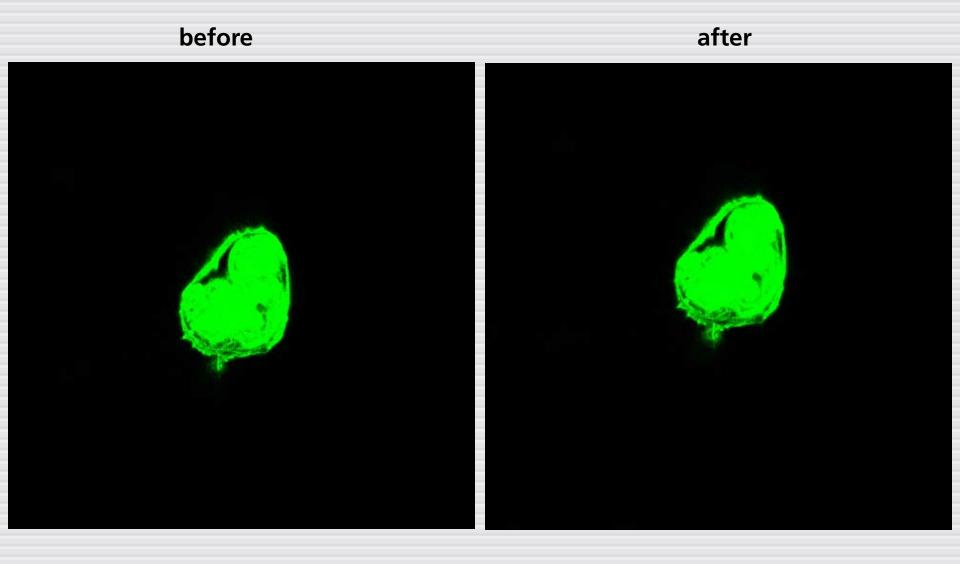


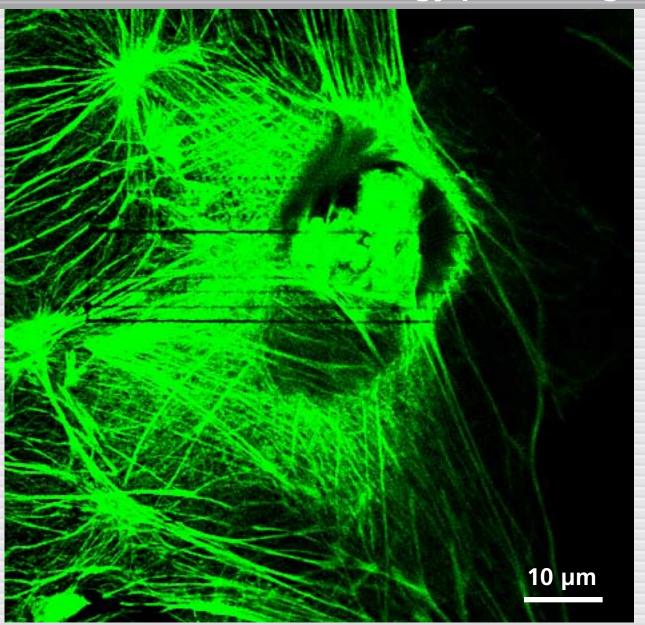


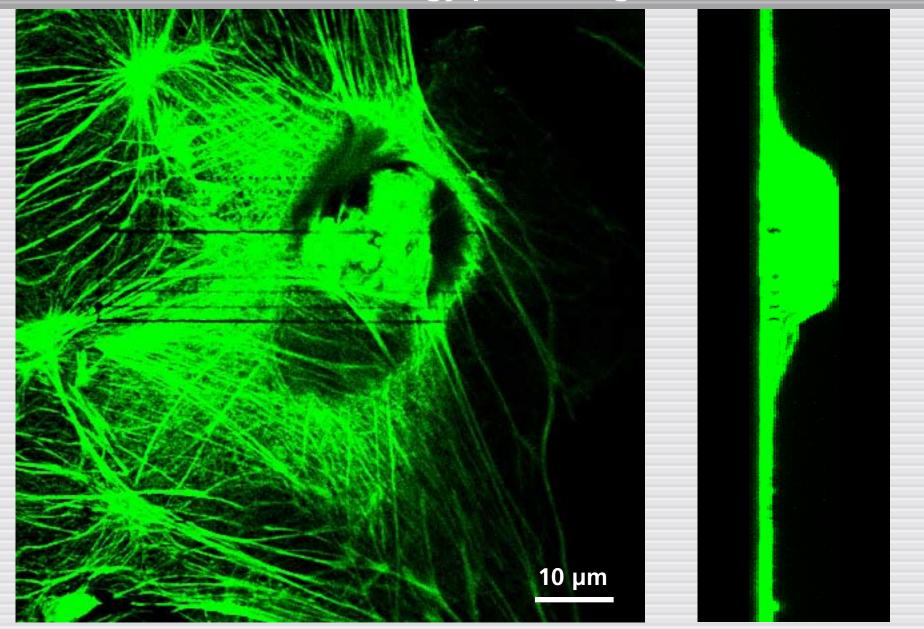


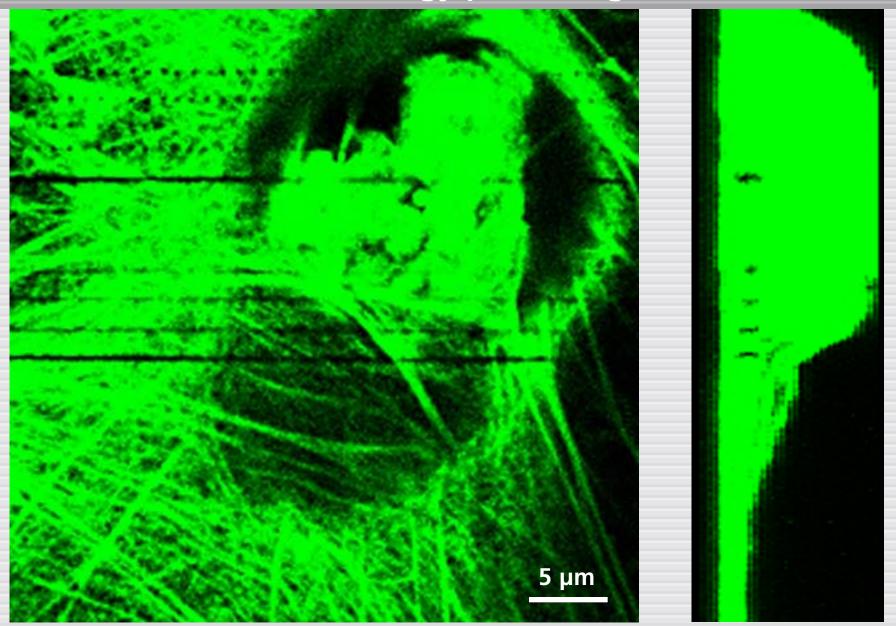


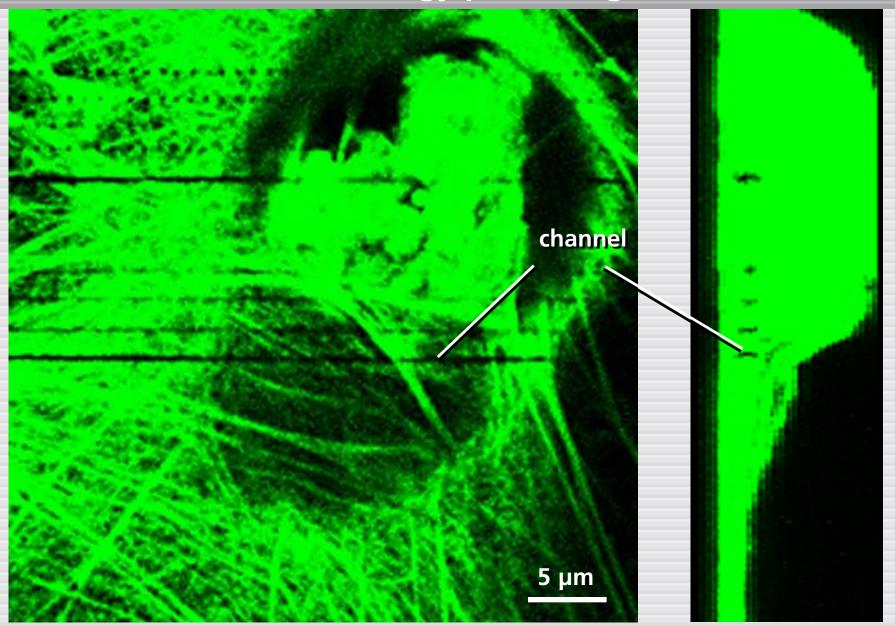


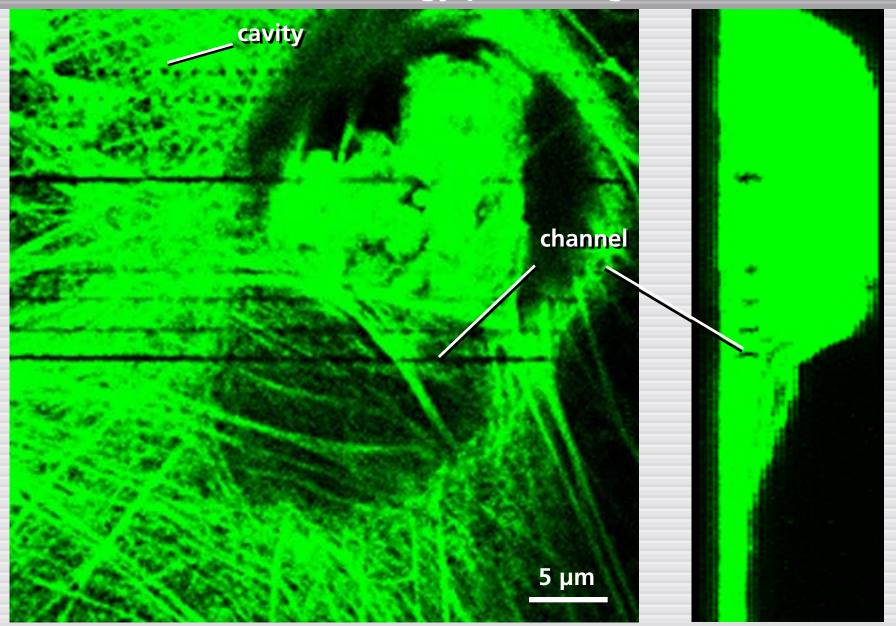


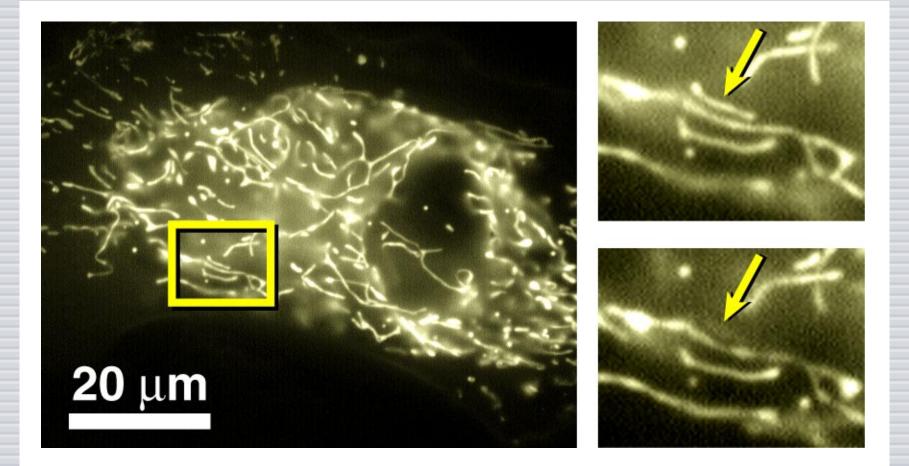


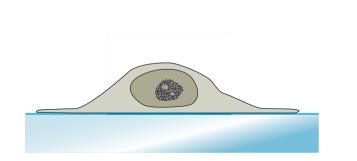


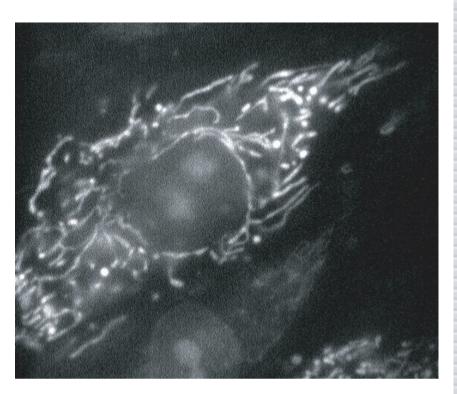


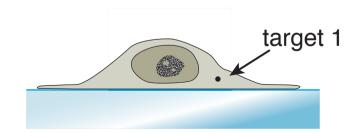


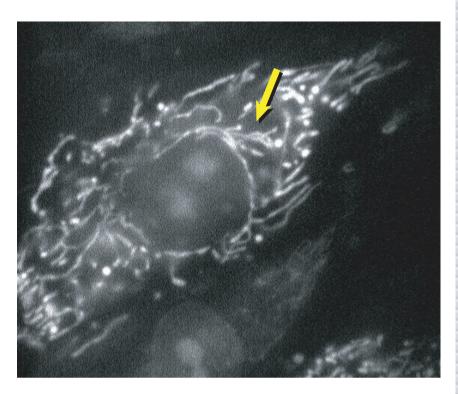


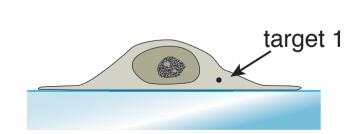


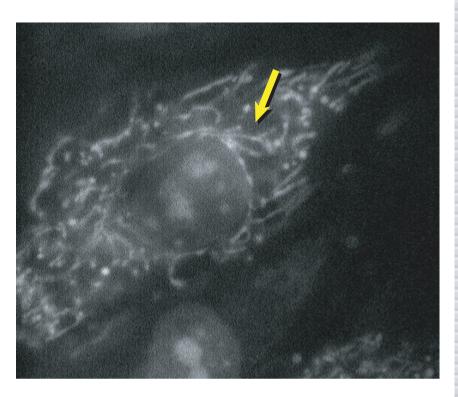


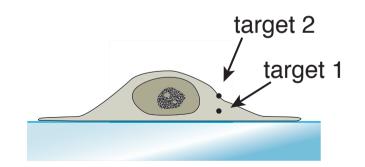


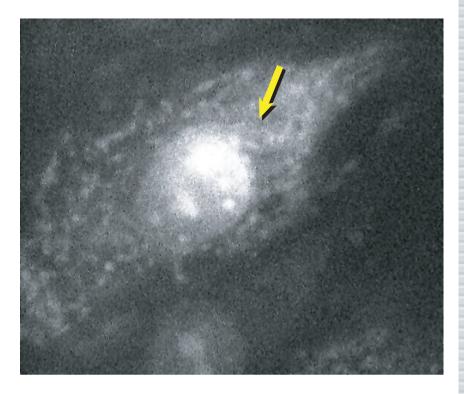


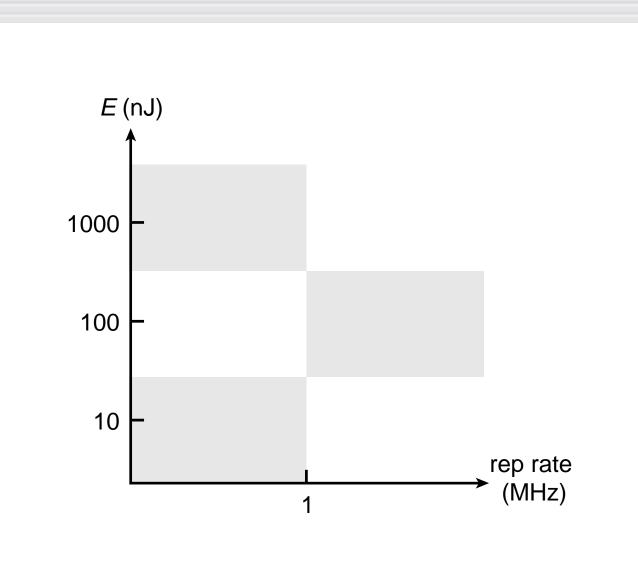


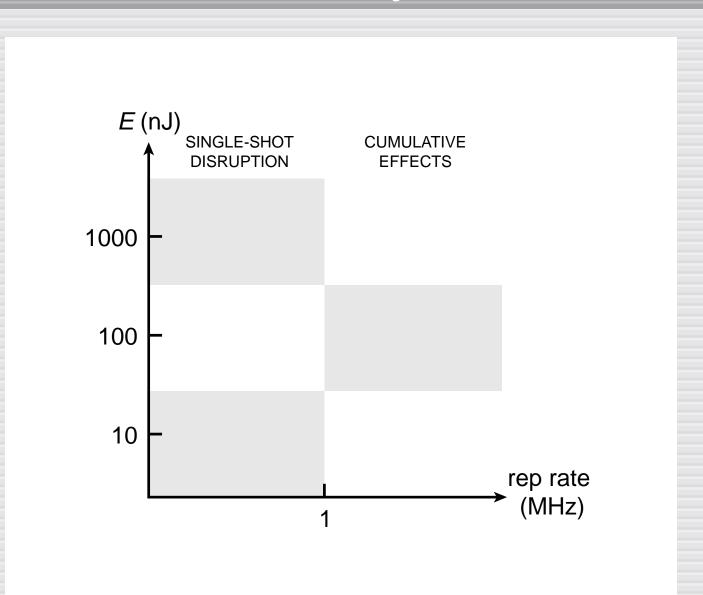


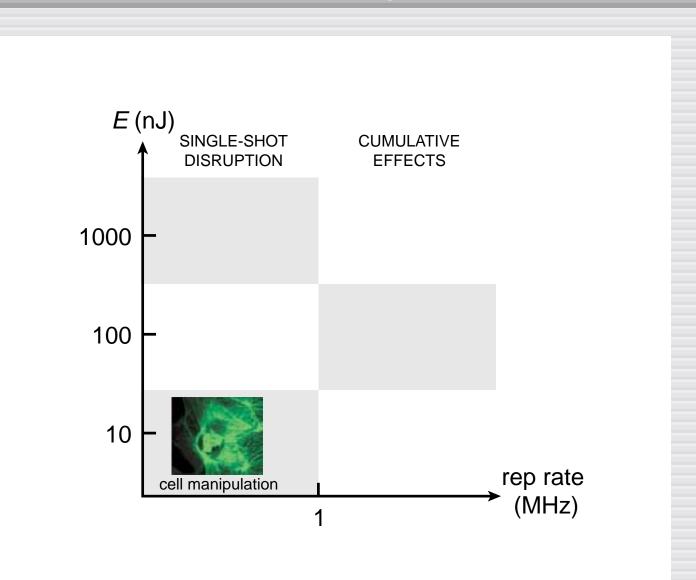


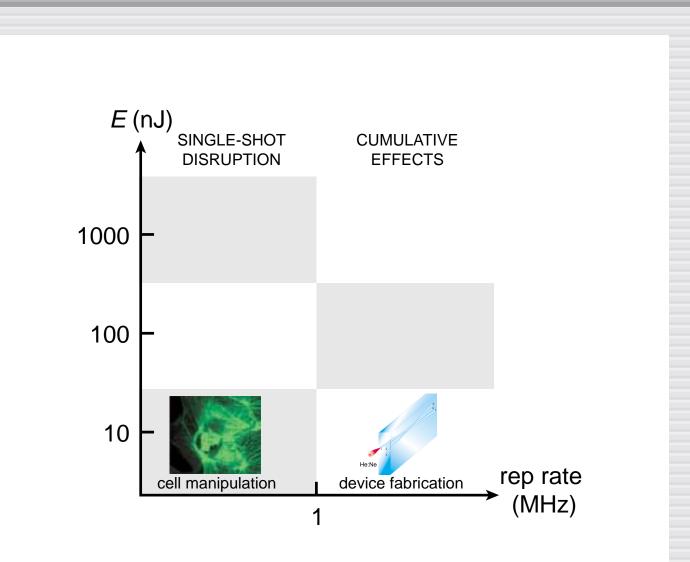


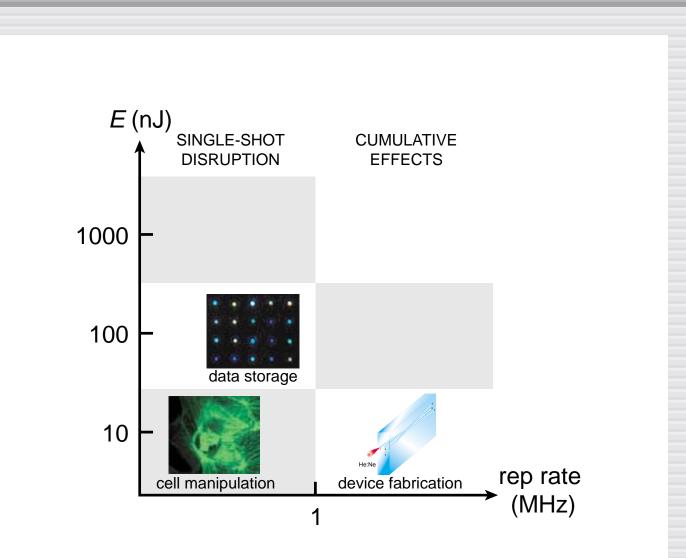


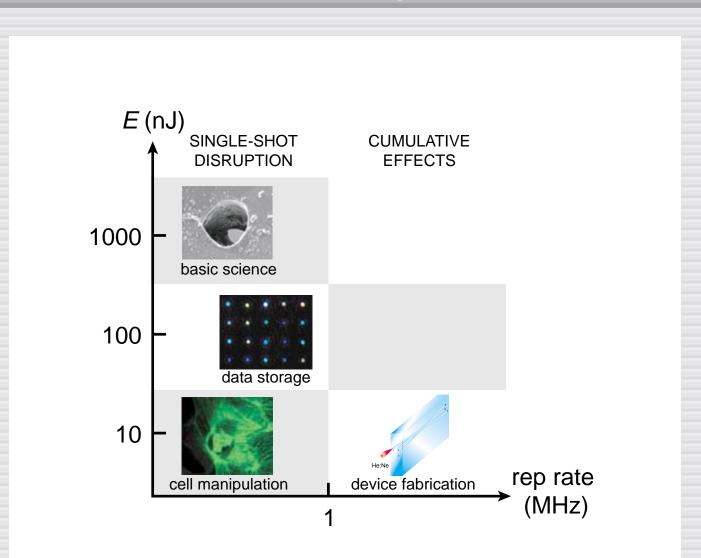
















manipulating the machinery of life



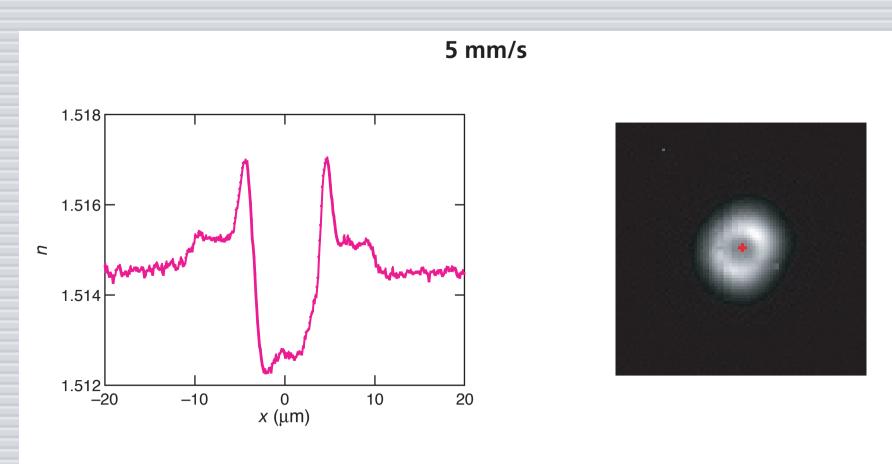
Funding: National Science Foundation Harvard Office of Technology and Trademark Licensing

Acknowledgments: Prof. Nico Bloembergen (Harvard University) Willie Leight (Yale University) Yossi Chai (Sagitta, Inc.)

For a copy of this talk and additional information, see:

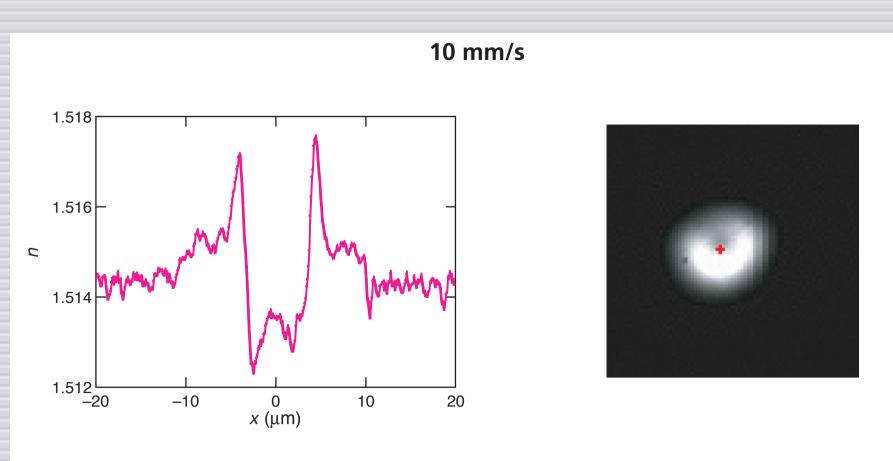
http://mazur-www.harvard.edu

refractive index profiles and near field mode at 633 nm



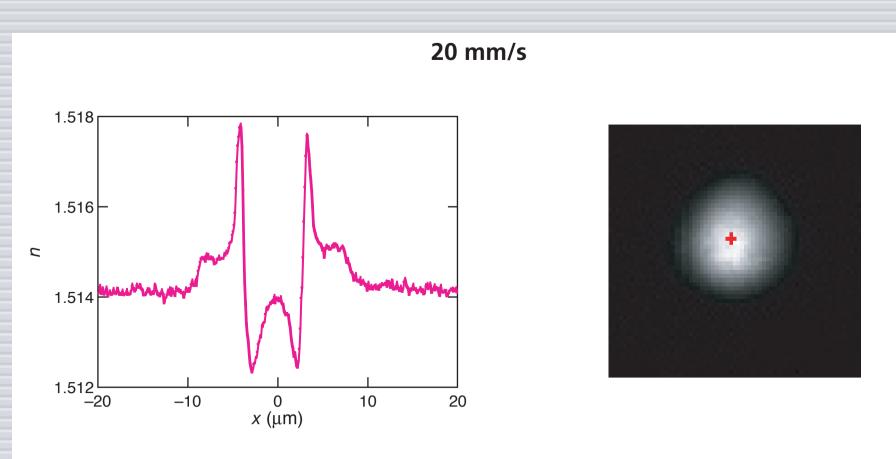
Sagitta, Inc.

refractive index profiles and near field mode at 633 nm



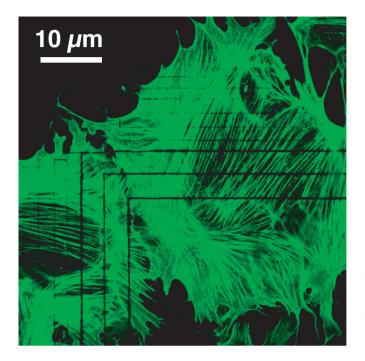
Sagitta, Inc.

refractive index profiles and near field mode at 633 nm



Sagitta, Inc.

bleaching or disruption?



bleaching or disruption?

